

Molecular chemistry approaches for tuning the properties of two-dimensional transition metal dichalcogenides

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Abstract

Two-dimensional (2D) semiconductors, such as ultrathin layers of transition metal dichalcogenides (TMDs), offer a unique combination of electronic, optical and mechanical properties, with potential to enable a host of new device applications spanning from flexible/wearable (opto)electronics to energy-harvesting and sensing technologies. A critical requirement for developing practical and reliable electronic devices based on semiconducting TMDs is achieving a full control over their charge-carrier polarity and doping. Inconveniently, such a challenging task cannot be accomplished by means of well-established techniques (*e.g.* ion implantation), which unavoidably damage the 2D crystals resulting in degraded device performances. Nowadays, a number of alternatives are being investigated, including various (supra)molecular chemistry approaches relying on the combination of 2D semiconductors with electroactive donor/acceptor molecules. As yet, a large variety of molecular systems have been utilized for functionalizing 2D TMDs *via* both covalent and non-covalent interactions. Such research endeavours enabled not only the tuning of the charge-carrier doping but also the engineering of the optical, electronic, magnetic, thermal and sensing properties of semiconducting TMDs for specific device applications. Here, we will review the most enlightening recent advancements in (supra)molecular chemistry

methods for tailoring the properties of atomically-thin TMDs — in the form of substrate-supported or solution-dispersed nanosheets — and we will discuss the opportunities and the challenges towards the realization of novel hybrid materials and devices based on 2D semiconductors and molecular systems.

1. Introduction

Two-dimensional (2D) materials represent an ever-growing research area that encompasses multiple disciplines and spans from fundamental science to novel device applications.¹⁻³ Such a terrific endeavour essentially took off in 2004 with the isolation of graphene from graphite *via* micromechanical cleavage, also known as scotch tape method.⁴ This simple-yet-effective technique was soon after utilized for the preparation of atomically-thin sheets of various layered van der Waals materials,⁵ including molybdenum disulfide (MoS₂) and other transition metal dichalcogenides (TMDs). Unlike graphene that is a semimetal and does not possess a bandgap in its pristine form⁶ — a property that is essential for application in digital electronics⁷ —, the family of layered-TMD materials offers a broad variety of electronic and optical properties, including semiconducting bandgaps in the visible range of the electromagnetic spectrum.^{8,9} Bulk TMD crystals were investigated back in the 1960s,¹⁰⁻¹² and TMD nanosheets with thickness < 100 Å were reported in 1966 by Frindt, who was pioneering the exfoliation of MoS₂ by adhesive-tape peeling at that time.¹³ Noticeably, in 1986 — that is almost two decades before the advent of graphene and 2D crystals^{4, 5} — Joensen, Frindt and Morrison¹⁴ succeeded in preparing single-layer thick sheets of MoS₂ *via* ion-intercalation methods.^{15, 16} Nowadays, ultrathin TMDs are among the most popular 2D materials *beyond graphene*,^{17, 18} with monolayer MoS₂ being their prototypical and most investigated element.¹⁹ After the demonstration, in 2011, of dual-gated single-layer MoS₂ transistors (ref. 20) with excellent $I_{\text{on}}/I_{\text{off}}$ switching ratio ($\sim 10^8$) and promising field-effect

mobility (up to $\sim 60 \text{ cm}^2 \text{V}^{-1} \text{s}^{-1}$),^{21, 22} tremendous research efforts have been devoted to exploring the use of 2D-TMD semiconductors — *e.g.* MoS₂, WS₂, MoSe₂ and WSe₂ — as active layers in electronic switches, such as field-effect transistors (FETs).²³⁻²⁶ Thanks to their atomic-scale thicknesses and sizable energy bandgaps (1-3 eV),²⁷ these materials offer ideal electrostatic control in the FET geometry,^{28, 29} and for this reason they have been proposed as potential alternatives to silicon for next-generation *More-than-Moore* technologies.^{30, 31} The transition from indirect to direct bandgap that occurs when the thickness of the TMDs is scaled down to a single layer,³²⁻³⁴ has also attracted great attention in view of potential applications in optoelectronic devices,^{26, 35-37} in particular photodetectors³⁸⁻⁴⁰ and solar cells.⁴¹⁻⁴⁴ Besides having excellent optical and electronic properties, ultrathin TMDs are also characterized by a high degree of mechanical flexibility, robustness and light weight,^{45, 46} which makes them ideal candidates for the fabrication of flexible, foldable and wearable/portable (opto)electronic devices.^{23, 47-49}

Though impressive advances have been made in this direction,^{17, 18} numerous challenges still need to be tackled towards practical and reliable technologies based on 2D semiconductors.^{1, 3, 23} In particular (i) the synthesis of large-area and high-quality films of monolayer TMDs with low densities of defects and impurities,^{16, 50} as well as (ii) the development of sound strategies to control the charge-carrier type and the doping level in 2D semiconducting crystals remain major challenges to be faced.^{1, 51-53} Whereas a lot of progress has been reported and reviewed on the synthesis of 2D-TMD sheets,^{16, 50, 54-56} seemingly, relatively less work has been focused on the second critical aspect, which is nevertheless a veritable bottleneck to the incorporation of 2D TMDs in (opto)electronic technologies.^{1, 51-53} Achieving a systematic control over charge-carrier doping is essential for minimizing detrimental Schottky barriers at metal-semiconductor interfaces,⁵⁷ as well as for manufacturing *p-n* junctions and transistors with reproducible electrical characteristics, which are crucial requirements for the production of

complementary-logic devices and circuits.⁵⁸ Conventional doping techniques, such as ion implantation and dopant diffusion, are extremely challenging to be implemented in combination with 2D TMDs, since damages/defects induced by such processes in ultrathin crystals can have drastic effects on their structural and electrical properties.⁵⁹⁻⁶¹ Various alternatives have been proposed — comprehensively reviewed in refs 51, 53 — such as alloying,⁶² transition-metal substitution/incorporation,⁶³⁻⁶⁶ plasma-assisted doping,⁶⁷ chalcogen substitution *via* defect engineering,^{68, 69} as well as charge transfer *via* interaction with molecular adlayers.²⁵ In particular, the use of molecular systems interfacing 2D semiconducting sheets is emerging as a promising, versatile and viable route for controlling the charge-carrier doping and polarity of ultrathin TMDs. Being essentially all surface, atomically-thin crystals are extremely sensitive to all influences of a surrounding environment, and their properties can thereof be easily modified by external variables.^{1, 70} For instance, FETs based on monolayer TMDs sheets were reported to be highly sensitive to a large number of gas molecules, which interact with the surface of the 2D semiconducting channel modulating its charge-carrier density *via* electrical dipoles or charge-transfer interactions.⁷¹⁻⁷⁴ Hence, one can take advantage of the exquisite sensitivity of ultrathin TMDs to tune their electronic and optical properties by controlling the physico-chemical variables of the surrounding environment,^{25, 70, 75} for instance by engineering *ad hoc* (supra)molecular systems interfacing the 2D sheets.^{70, 75}

Indeed, a variety of molecular chemistry approaches (see Fig. 1), based on covalent⁷⁶⁻⁸⁰ and non-covalent⁸¹⁻⁸³ interactions between molecules and defective/pristine TMDs, have been reported in the last few years. Such studies enabled not only the tuning of the charge-carrier doping^{81, 84-90} but also the tailoring of other functional properties critical for (opto)electronic applications, such as for instance charge transport,^{25, 64, 91-93} charge injection,^{94, 95} optical

emission and adsorption,⁹⁶⁻¹⁰³ as well as dispersibility in liquid media (inks),¹⁰⁴⁻¹⁰⁶ the latter being crucial for the processing of large-area films and devices.^{107, 108}

In this review article, we will describe and discuss the molecular chemistry strategies that have been pursued so far to functionalize 2D TMDs — in particular the so-called MoWSeS materials (*i.e.* MoS₂, WS₂, MoSe₂ and WSe₂)² — and to control their charge-carrier doping along with other materials' characteristics. It is worth noting that such strategies have been implemented both on substrate-supported 2D layers (Sections 2-4) and on dispersions of TMD nanosheets in solution (Section 5). More specifically, Section 2 will be focused on non-covalent methods to decorate the top and bottom surfaces of 2D TMDs with electroactive (*i.e.* donor and acceptor) molecules, which can be eventually deposited in the form of highly-ordered molecular layers.⁸³ Afterwards, we will show how chemical methods can be employed to control and optimize optical processes in 2D semiconductors, *e.g.* the photoluminescence emission in direct-bandgap monolayer TMDs (Section 3). Recently, various defect- and phase-engineering approaches have been developed for functionalizing ultrathin TMDs *via* covalent binding of molecular species onto their basal-plane surface.^{80, 109} These techniques will be presented in Section 4. Research endeavours have also been devoted to the development of liquid-phase methods for tailoring the properties of semiconducting nanosheets dispersed in aqueous or organic solutions with a number of molecules and (bio) polymers.¹¹⁰⁻¹¹² The availability of inks of functionalized TMDs is expected to open up novel possibilities for the processing of large-area hybrid materials and devices — *e.g.* by making use of ink-jet printing methods¹⁰⁶ — based on combinations of 2D semiconductors and molecular systems (Section 5). Due to their broader commercial availability and well-established exfoliation processes, MoWSeS materials are the most investigated among the TMDs,⁹ and only a few experimental and theoretical works exist on the effects of functional

molecules on the (opto)electronic properties of other TMD materials (*e.g.* group-10 PdSe₂ and group-5 NbSe₂),^{113, 114} which have been grouped and reviewed all together in Section 6.

Molecular-design strategies can be used to “bridge” a virtually-infinite number of molecules to 2D crystals (Section 1.2), providing unique opportunities not only to modulate the properties of ultrathin TMDs — on demand for device applications — but also to introduce new functionalities with the aim of developing novel multifunctional/multiresponsive materials and devices. These opportunities and the associated challenges will be discussed in the last part of this review (Section 7).

1.1 Materials and properties

Single sheets of TMDs, commonly indicated with the formula MX₂, consist of an atomic layer of transition metals (M = Mo, W, Ti, Nb, Ta, Re, Pt, Pd *etc.*) sandwiched between two atomic layers of chalcogens (X = S, Se and Te).^{11, 115} More than 40 bulk MoX₂ crystals — resulting from different permutations of M and X elements — are available in nature, and most of them possess a layered structure.^{26, 115} In such layered materials, the atoms within individual sheets are connected *via* strong covalent bonds (1-10 eV/atom), whereas adjacent sheets interact with each other through weak van-der-Waals forces (10s of meV/atom).^{1, 2, 115} For this reason, similarly to graphite and other layered materials,¹¹⁶ TMDs can be easily exfoliated into single- and few-layer thick nanosheets by making use of various techniques, including micromechanical cleavage *via* scotch-tape peeling,^{5, 13} as well as liquid-phase methods based on intercalation of ions (chemical exfoliation),¹¹⁷⁻¹²¹ ultrasonication/shear exfoliation in organic solvents^{122, 123} or aqueous surfactant solutions.¹⁰⁵ Nowadays, graphene is not the only 2D material to be available in the form of high-quality large-area films produced *via* chemical vapour deposition (CVD).^{124, 125} In fact, ultrathin films of MoWSeS materials^{50, 54, 126-128} and other TMDs (*e.g.* ReS₂¹²⁹ and SnSe₂¹³⁰) can also be grown by CVD methods on technologically-relevant substrates (*e.g.* oxidized Si wafers), and lateral heterostructure of

different 2D semiconductors — promising for next-generation (opto)electronic devices — have already been reported in the literature.^{131, 132}

Nowadays, ultrathin TMDs are intensively investigated for applications in electronic switches, *p-n* junctions, logic gates and optoelectronic devices.^{23, 27, 35} In fact, several high-quality semiconducting TMDs are currently available with various electronic properties, as well with different charge-transport polarity. For instance, ultrathin MoS₂ behaves as a unipolar *n*-type semiconductor, whereas 2D WSe₂ commonly displays ambipolarity.²⁷

Crystal Structures. TMDs can have multiple crystal structures, depending on the mutual coordination of the M and X elements,^{115, 133} and transitions between different phases have been predicted¹³⁴ and triggered experimentally *via* multiple physico-chemical stimuli.¹³⁵ The most common polytypes (see Fig. 2) are the hexagonal — indicated as 1H for single layers and 2H for multilayers — with trigonal prismatic (D_{3h}) coordination, and the tetragonal 1T with octahedral coordination (O_h).^{115, 133} The 1T polytype often undergoes a lattice distortion into a 1T' form, as for instance in the case of MoTe₂.^{136, 137} For monolayer MoWSeS, the most stable polytype is 1H, which is associated with semiconducting properties and direct bandgaps.^{8, 138, 139} However, metastable 1T/1T' polytypes with metallic characteristics can be prepared with various methodologies.¹³⁵ In 1991, Sandoval *et al.*¹⁴⁰ demonstrated that monolayer MoS₂ sheets produced *via* lithium-ion intercalation have octahedral phase, and they also proposed a possible 1T' distorted configuration. Such results were confirmed by a number of subsequent works (*e.g.* refs 121, 141-143) along with possible strategies for prompting transitions between the metallic 1T/1T' and the semiconducting 1H phases. In 2011, Eda *et al.*¹⁴² reported on photoluminescence emission — typical of 1H semiconductors — from MoS₂ nanosheets produced *via* lithium-ion intercalation. The key to this achievement was the 1T/1T'→1H conversion triggered by thermal annealing ($T \geq 300$ °C) after deposition on a substrate.¹⁴² This work stimulated the investigation of phase-engineering techniques for

modulating the properties of ultrathin TMDs, which can be conveniently utilized in combination with molecular chemistry approaches,^{77, 80} as discussed in Section 4. The properties and the stability of different polytypes in TMDs “beyond MoWSeS” can vary significantly, depending on the *d*-electron number of the transition metal (see Section 6).^{9, 130, 131} For example, monolayer PtSe₂ (group 10) is a 2D semiconductor with indirect bandgap of ~1.2 eV (theory)^{138, 139} and 1T stable polytype;¹⁴⁴ NbSe₂ nanosheets (group 4) have stable 1H/2H metallic phase and were shown to maintain superconducting characteristics down to the monolayer thickness;¹⁴⁵ single-layer MoTe₂ (group 6) displays a 1T' semimetallic polytype that is almost as stable as its 1H counterpart,^{146, 147} whereas ultrathin ReS₂ (group 7) presents a distorted semiconducting 1T' structure with diamond-shape lines that are responsible for strongly anisotropic transport properties.^{148, 149} Here, we will not enter into the details of such a wealth of structures and properties, which have been thoroughly presented elsewhere (*e.g.* refs 9, 27, 115, 150). However, we point out that the physico-chemical properties of ultrathin TMDs, as well as their interactions with their surroundings, can vary dramatically with the 2D-material structural phase,⁸⁰ and such variability cannot be overlooked when dealing with molecular chemistry methods for the functionalization of ultrathin TMDs.

Defects. Another important aspect to consider is the fact that materials, in general, have defects. Though often regarded as detrimental and undesired due to the fact that they perturb the peculiar material's properties, defects have also been exploited for introducing novel functionalities in (opto)electronic devices,^{151, 152} and are being regarded as chemically-active sites suitable for the chemical functionalization of 2D materials, among which graphene¹⁵³ and ultrathin TMDs.^{79, 88} In the case of exfoliated 2D sheets, topological and structural defects can be inherited from the source bulk crystals, and they can also be generated during the exfoliation process.^{154, 155} In CVD films, the synthesis/growth leads not only to point defects,

but also to grain boundaries (GBs), which affect the charge-transport properties in 2D electronic devices.^{156, 56} Also in this context, MoS₂ is the most studied among the TMD crystals.⁶⁹ Its defects and their influences on various physical properties have been extensively investigated, both experimentally¹⁵⁷⁻¹⁶⁷ and theoretically.^{165, 168-174} In comparison, a relatively smaller number of works have focused on other TMDs, and in particular MoWSeS materials.^{172, 175-180}

Vacancies are a common type of point defects in ultrathin TMD samples and have been found in multiple forms — *e.g.* single or double, M or X vacancies — as recently reviewed by Lin *et al.*⁶⁹ In the case of MoS₂ monolayers prepared by micromechanical cleavage, aberration-corrected transmission electron microscopy (TEM) studies were reported in 2013 by Qiu *et al.*,¹⁵⁷ who showed that sulfur vacancies (SVs) — see Fig. 2c and d — are the most abundant type of defects in exfoliated MoS₂ nanosheets, and can reach densities of the order of $\sim 10^{13}$ cm⁻², corresponding to approximately 10 SV over an area of 10×10 nm². Two years later, Hong *et al.*,¹⁶⁴ carried out a systematic TEM investigation and acquired statistical information on the quantities/types of defects in various MoS₂ samples. In agreement with the previous work,¹⁵⁷ they found that single SVs (V_{S1}) can achieve concentrations as high as 1.2×10^{13} cm⁻² in both mechanically-exfoliated and CVD-grown MoS₂ monolayers. Noticeably, double SVs (V_{S2}) were found to be present mainly in exfoliated nanosheets with densities in the range of $\sim 10^{12}$ cm⁻².¹⁶⁴ The landscape of defects/disorder in CVD monolayer MoS₂ can be more complex, as shown by Zhou *et al.*¹⁵⁸ Besides the most abundant SVs, there are also GBs, dislocations, as well as different types of point defects, such as vacancies of Mo-S complexes and antisite defects.^{69, 158}

The variety and abundance of defects in MoS₂ and other TMDs is being regarded as a major problem to the implementation of practical and reliable (opto)electronic devices based on 2D semiconductors. However, defects can also be exploited to advantage for the chemical

functionalization of the ultrathin nanosheets. In fact, whereas the basal plane of pristine 2D TMDs lacks of dangling bonds and therefore is rather chemically inert, defect-rich surfaces allow for different chemical reactions to occur, as in the case of SV-containing MoS₂.^{109, 181-186} It is worth noting that the edges of TMD crystals are also highly chemically reactive and have been widely investigated because of their excellent catalytic properties.¹⁸⁷⁻¹⁹¹ Moreover, chalcogen- and metal-rich edges are being regarded as suitable targets for the chemical functionalization of liquid-phase exfoliated nanosheets (see Section 5),¹⁹²⁻¹⁹⁶ enabling the production of functional TMD inks for (opto)electronic¹⁹⁷ as well as biomedical applications.¹⁹⁸

In the last few years, several defect-engineering strategies have been developed for tailoring the physico-chemical properties of 2D TMDs,⁶⁹ opening new routes for the functionalization of TMDs *via* molecular chemistry methods (Section 4.1).

1.2 “Bridging” ultrathin TMDs with molecular systems

Numerous advantages arise from the functionalization of ultrathin TMDs with molecular systems. Besides offering unique opportunities for tailoring the electrical, optical, thermal and sensing properties of TMDs, such a combination makes it also possible to develop novel multifunctional/multiresponsive hybrid materials and devices suitable for advanced logic, memory and sensing applications.¹⁹⁹ Indeed, functionalization methods aiming at “bridging” these two worlds have been intensively investigated over the past few years.^{76, 111, 198, 200} In particular, molecular chemistry offers a variety of techniques to achieve this objective, as illustrated in Fig. 1. The simplest technique is based on the physisorption of electroactive molecules on substrate-supported nanosheets, which can be achieved *via* solution-processing (*e.g.* refs 87, 201) or vapour-phase (*e.g.* ref. 202) deposition. A more elaborated approach consists in the use of the principles of supramolecular chemistry to control the ordering of molecules *via* self-assembly.^{83, 203} Highly-ordered crystalline assemblies of physisorbed

molecules can be grown on 2D materials by drop casting or spin coating,^{93, 203} resulting in spatially uniform periodic interactions between the 2D sheets and the molecular adlayers.⁹³ In addition, the packing and orientation of the molecules can be engineered *ad hoc* in order to modulate the magnitude/direction of surface dipoles, as well as the charge transfer between the molecular layers and the 2D crystal.⁹³ This represents an intriguing opportunity for tuning the charge-carrier doping in ultrathin TMDs, eventually by bringing into play cooperativity or collective processes.²⁰⁴ A slightly different technique involves the preparation of self-assembled monolayers (SAMs) *via* molecular chemisorption on suitable substrates, followed by the deposition/transfer of the 2D sheets (*e.g.* refs 84, 92). More in general, the TMDs' electronic and optical properties can be tailored by controlling the substrate surface chemistry, which can be accomplished with multiple approaches, including the use of polymer coating layers.^{205, 206}

In all the cases discussed above, the functionalization is achieved through non-covalent interactions between the molecules and the 2D sheets. However, it is also possible to “bridge” ultrathin TMDs and molecules *via* strong and stable covalent bonds, *e.g.* by exploiting defect and phase-engineering approaches^{69, 207} to activate and harness the chemical reactivity of the TMDs' surface. For instance, ultrathin layers of MoS₂ containing SVs can be “decorated” with molecules bearing nucleophilic functional groups — especially thiols^{88, 109} — that can coordinate/bind to the exposed molybdenum atoms at SV sites.^{181, 183, 184} Whereas the semiconducting 1H/2H phase of MoS₂ cannot be easily functionalized in the absence of defects,¹¹⁰ its electron-rich 1T/1T' counterpart allows for numerous functionalization routes,¹¹¹ since the occurrence of bond-forming reactions is facilitated by electron transfer between the metallic sheets and the reactant species (*e.g.* electrophiles such as organohalides).⁸⁰ Hence, one can exploit phase-conversion processes in TMDs¹³⁵ (see Section 1.1) to obtain metallic polytypes suitable for chemical functionalization, and eventually

convert them back to their original phase, as demonstrated by Voiry *et al.*⁸⁰ Noticeably, all these approaches can be conducted directly in solution — *e.g.* in the case of liquid-phase exfoliated TMDs (Section 5) — or on substrate-supported sheets, as outlined in detail below.

2. Tuning the properties of TMDs *via* non-covalent interactions

In conventional semiconductor technology, precise control over the optoelectronic properties of materials can be achieved by substitutional doping, which consists in replacing host atoms of the crystal with dopant impurities.^{58, 151} In ultrathin TMDs, doping can be accomplished by decorating their surface with electroactive (*i.e.* donor or acceptor) molecules, which can be used to controllably tune the charge-carrier density through diverse electromagnetic interactions (*e.g.* electrostatic and van der Waals). Indeed, the ultra-high surface-to-volume ratio in 2D TMDs makes their optoelectronic properties extremely sensitive to any variation in their surface environment. While substitutional doping has also been successfully applied to TMDs,^{63, 65, 79, 208} the non-covalent molecular approach (*i.e.* physisorption) has the advantage of leaving the crystal structure of TMDs unaltered, preserving their superior optoelectronic properties.

Two major mechanisms lead to the molecular doping of TMDs, which are (i) charge transfer and (ii) dipolar interactions. Charge transfer occurs when the electrochemical redox potential of the molecules and the Fermi level of 2D materials comply with certain conditions. When the redox potential of a given molecular dopant lies below the TMD Fermi level, electron transfer can occur from the TMD sheet to the molecule, resulting in *p*-type doping.²⁰⁹ *Vice versa*, when the redox potential of molecules lies above the TMD Fermi level, electrons are transferred from the molecules to the TMD, inducing *n*-type doping.⁸⁵ Fig. 3 compares the reduction potentials of various molecular dopants with the band edges — namely the electron affinity (conduction band minimum, CBM) and the ionization potential (valence band maximum, VBM) — of group-6 monolayer TMDs.²¹⁰ Although the exact Fermi level position

of TMDs depends on several factors (*e.g.* impurities, substrate, crystal defects, *etc.*), the figure provides a guideline for the choice of suitable molecules to realize doping in monolayer TMD sheets based on possible charge-transfer processes involving the CBM/VBM levels of TMDs. It should be noticed that the band edges are characterized by a significant uncertainty; for instance, the electron affinity of 1L MoS₂ has been reported to vary from ~ 3.9 eV (ref. 211) to ~ 4.7 eV (ref. 212).

Dipolar interactions can also be exploited for tuning the charge-carrier doping in ultrathin TMDs. Molecules with permanent dipole moments generate electric fields on the 2D-sheet surface, modulating the (local) charge carrier density similarly to nanoscopic electric gates. If the dipole moments of several molecules lying on the TMD surface possess the same spatial orientation, single-molecule effects can sum up leading to a macroscopic modification of the TMD energetics. In particular, a shift in the Fermi level of semiconducting TMDs was observed as a consequence of the interaction with well-aligned molecular dipoles,⁸⁴ resulting in *p*- or *n*- type doping depending on the dipole direction.⁸⁶ In most cases, both mechanisms contribute to the doping effect, and it is often difficult to disentangle the two contributions.⁹²

In this section, we will summarize the doping of TMDs through the decoration of their top and bottom surfaces with electroactive molecular systems. As an overview, Table 1 provides a summary of the molecules that have been used to decorate ultrathin TMDs, highlighting their impact on the optoelectronic and vibrational properties, as well as the mechanisms responsible for the measured effects.

Table 1. Effects of molecular dopants on the electronic (doping), vibrational (A_{1g} , and E_{2g}^1 Raman modes) and optical (PL) properties of substrate-supported ultrathin TMDs. Notes: CT, charge transfer; DI, dipolar interactions; PI-CT, photo-induced charge transfer; RS, red shift; BS, blue shift; FWHM, full width at half maximum. (*) TMD coated with a hybrid PMMA/F₄-TCNQ layer.

Ref.	Molecules	TMD	Doping mechanisms	Doping type	Doping density $\Delta Q/e [\text{cm}^{-2}]$	Effect on PL	Effect on Raman modes	Functional group interacting with TMDs	Stability	Deposition method
<i>Decoration of the top surface</i>										
85	benzyl viologen (BV)	MoS ₂	CT	<i>n</i>	$\sim 10^{13}$		A_{1g} RS, FWHM \uparrow		9 days	drop cast or soaking
209	nicotinamide adenine dinucleotide (NADH)	MoS ₂	CT	<i>n</i>		RS, I \downarrow		-NH ₂		drop cast
88	mercaptoethylamine (MEA)	MoS ₂	CT	<i>n</i>	3.7×10^{12}	RS, I \downarrow		-NH ₂	1 week	soaking
94	polyethyleneimine (PEI)	MoS ₂	CT	<i>n</i>				-NH ₂	unstable	soaking
101	triphenylphosphine (PPh ₃)	MoS ₂	CT	<i>n</i>	1.6×10^{11}		A_{1g} , E_{2g}^1 RS, A_{1g} FWHM \uparrow		14 days	spin-coating
101		ReSe ₂	CT	<i>n</i>	1.1×10^{11}				14 days	spin-coating
213		WSe ₂	CT	<i>n</i>	7.8×10^{11}		A_g , E_g RS, A_g FWHM \uparrow A_{1g} , E_{2g}^1 BS		8 days	spin-coating
214	hydrazine	WSe ₂	CT	<i>n</i>			A_{1g} , E_{2g}^1 RS	-NH ₂		soaking
88	1H,1H,2H,2H-perfluorodecanethiol (FDT)	MoS ₂	CT		1.8×10^{11}	BS, I \uparrow		-CF ₃		soaking
209	tetracyanoquinodimethane (TCNQ)	MoS ₂	CT	<i>p</i>		BS, I \uparrow				drop cast

209	tetrafluoro-7,7,8,8-tetracyanoquinodimethane (F ₄ -TCNQ)	MoS ₂	CT	<i>p</i>	5.8×10 ¹³	BS, I ↑		-F	2 weeks	drop cast
215		WSe ₂	CT	<i>p</i>				-F		(*)
216		WS ₂	CT	<i>p</i>	7.4×10 ¹³	BS, I ↑	A _{1g} , BS	-F		drop cast
99	magnesium phtalocyanine (MgPc)	MoS ₂								soaking
99		MoSe ₂								soaking
99		WSe ₂	PI-CT	<i>p</i>		I ↓				soaking
99	nickel phtalocyanine (NiPc)	MoS ₂								soaking
99		MoSe ₂	PI-CT	<i>p</i>		I ↓				soaking
99		WSe ₂	PI-CT	<i>p</i>		I ↓				soaking
217	titanyl phthalocyanine (TiOPc)	MoS ₂	CT	<i>p</i>		I ↑				evaporation
^{39, 86}	octadecyltrichlorosilane (ODTS)	WSe ₂	DI	<i>p</i>	1.8×10 ¹¹	I ↓	A _{1g} , E _{2g} ¹ BS	-CH ₃	100 hours	soaking
39		MoS ₂	DI	<i>p</i>	1.4×10 ¹¹	I ↑	A _{1g} , E _{2g} ¹ BS	-CH ₃		soaking
39	3-(trimethoxysilyl)-1-propanamine (APTES)	WSe ₂	DI/CT	<i>n</i>	1.1×10 ¹¹	I ↑	A _{1g} , E _{2g} ¹ RS	-NH ₂		soaking
39		MoS ₂	DI/CT	<i>n</i>	1×10 ¹¹	I ↓	A _{1g} , E _{2g} ¹ RS	-NH ₂		soaking
81	oleylamine	MoS ₂	DI/CT	<i>n</i>	1.8×10 ¹³	RS	A _{1g} RS	-NH ₂		soaking
102	methyl salicylate	MoS ₂		<i>p</i>		I ↑	A _{1g} BS			spin-coating
218	perylene-diimides	MoS ₂	CT	<i>n</i>						drop cast
218	tetraphenyl porphyrins	MoS ₂	CT	<i>n</i>						drop cast
102	benzoic acid	MoS ₂		<i>p</i>		I ↑	A _{1g} BS	-COOH		spin-coating
102	phenol	MoS ₂		<i>p</i>		I ↑	A _{1g} BS	-OH		spin-coating
102	salicylic acid	MoS ₂		<i>p</i>	9×10 ¹³	I ↑	A _{1g} BS	-COOH		spin-coating
102	nitrobenzene	MoS ₂		<i>p</i>		I ↑	A _{1g} BS	-NO ₂		spin-coating

102	aniline	MoS ₂		<i>p</i>		I ↑	A _{1g} BS	-NH ₂	spin-coating
102	melamine	MoS ₂		<i>p</i>		I ↑	A _{1g} BS	-NH ₂	spin-coating
219	fluorinated fullerene (C ₆₀ F ₄₈)	WSe ₂	CT	<i>p</i>	1×10 ¹²			-F	evaporation
84	octyltrichlorosilane (OTS)	MoS ₂	DI	none	none	none	none	-CH ₃	SAM
92	octadecyltrichlorosilane (ODTS)	MoS ₂	DI	<i>p</i>	5×10 ¹¹			-CH ₃	SAM
220	DNA	MoS ₂	DI	<i>n</i>	6×10 ¹⁰		A _{1g} , E _{2g} ¹ RS	phosphate	drop cast
		WSe ₂	DI	<i>n</i>	7×10 ⁹		A _{1g} , E _{2g} ¹ RS		
220	metal DNA	MoS ₂	DI	<i>p/n</i>	1-5×10 ¹⁰		A _{1g} , E _{2g} ¹ BS	Zn, Ni, Co, Cu, Eu,	drop cast
221		WSe ₂	DI	<i>p/n</i>			A _{1g} , E _{2g} ¹ BS	Gd, Tb, Er	
87	tris(4-bromophenyl)ammoniumyl hexachloroantimonate (Magic Blue)	MoS ₂	CT	<i>p</i>	8×10 ¹²		A _{1g} , E _{2g} ¹ BS		dip coating
87	2-ferrocenyl N,N'-dimethylbenzimidazole ((2-Fc-DMBI) ₂)	MoS ₂	CT	<i>n</i>	6.3×10 ¹²		A _{1g} , E _{2g} ¹ RS		dip coating
87	2-ferrocenyl-2,3-dihydro-1H-benzimidazole (2-Fc-DMBI-H)	MoS ₂	CT	<i>n</i>	5.2×10 ¹²		A _{1g} , E _{2g} ¹ RS		dip coating
<i>Decoration of the bottom surface</i>									
84	3-(trimethoxysilyl)-1-propanamine (APTES)	MoS ₂	DI	<i>n</i>			A _{1g} RS,	-NH ₂	SAM
92		MoS ₂	DI/CT	<i>n</i>	1×10 ¹¹	I ↑	FWHM ↑	-NH ₂	SAM
84	trichloro-(1H,1H,2H,2H-perfluorooctyl)silane (FOTS)	MoS ₂	DI	<i>p</i>			A _{1g} BS,	-CF ₃	SAM
92		MoS ₂	DI/CT	<i>n</i>	8×10 ¹¹		FWHM ↓	-CF ₃	SAM
92	(3-mercaptopropyl)trimethoxysilane (MPS)	MoS ₂	DI/CT	<i>n</i>	1×10 ¹¹	I ↑		-SH	SAM
222	(E)-6-(4-(phenyldiazenyl)phenoxy)hexane-1-thiol (HS-C ₆ AZO)	MoS ₂	DI/CT	<i>n</i>		I ↓		-phenyl	SAM
222	(E)-6-(4-((4-chlorophenyl)diazenyl)-phenoxy)hexane-1-thiol (HS-C ₆ AZO-Cl)	MoS ₂	DI/CT	<i>p</i>		I ↑		-Cl	SAM

2.1 Physisorption of electroactive molecules

Crystal defects and impurities introduced with conventional doping techniques can significantly affect the electrical characteristics of FETs based on monolayer TMDs, including the field-effect mobility, the threshold voltage and the subthreshold swing.^{109, 223, 224} Moreover, they can degrade the performances of optoelectronic devices in terms of photoresponsivity and light emission.^{175, 225} The physisorption of electroactive molecules on the surface of ultrathin TMD sheets represents an alternative non-destructive method for tuning doping *via* charge transfer, as discussed previously. One of the most studied molecules is 2,3,5,6-tetrafluoro-7,7,8,8-tetracyanoquinodimethane (F₄-TCNQ), which is a common electron acceptor (*p*-dopant).²⁰⁹ The redox potential of F₄-TCNQ lies below the CBM of monolayer MoS₂ (see Fig. 3) so that electron transfer can occur from the conduction band of heavily *n*-doped MoS₂ — where the Fermi level lies close to the CBM — to the unoccupied energy states of the F₄-TCNQ molecules, resulting in electron depletion. The *p*-doping effect is evident from the evolution of the photoluminescence (PL) spectra upon molecular physisorption (Fig. 4a). The A exciton, which is associated with optical transitions at the K point of the Brillouin zone, consists of both negatively-charged excitons (*i.e.* trions, $E(X^-)$ \approx 1.84 eV) and neutral excitons ($E(X)$ \approx 1.88 eV), so that the trion spectral weight depends on the amount of doping in the 2D semiconducting sheet.²²⁶ For the as-exfoliated MoS₂, the trion intensity was found to be higher than that of the neutral exciton (see fitting in Fig. 4c) due to the *n*-type doping typically occurring in natural MoS₂ crystals.¹⁹ On the other hand, in the F₄-TCNQ-doped MoS₂ the contribution of the neutral exciton becomes dominant due to electron depletion, the A peak blue shifts and its intensity increases dramatically.

Different from F₄-TCNQ, nicotinamide adenine dinucleotide (NADH) has a redox potential higher than the CBM of monolayer MoS₂ (see Fig. 3) and therefore can be used for *n*-type doping. After physisorption of NADH molecules, the PL spectra of monolayer MoS₂ (Fig. 4b)

are characterized by a higher trion spectral weight. Moreover, the A peak red-shifts and its intensity decreases, due to electron accumulation in the 2D material. Hence, through the molecular physisorption approach both the charge-carrier doping and the PL emission spectra can be effectively modulated.

Similar results were obtained by Peimyoo *et al.*²¹⁶ by making use of monolayer (1L) WS₂ sheets in combination with F₄-TCNQ molecules. The authors investigated the effects of molecular physisorption on the electrical properties of back gated 1L-WS₂ FETs (Fig. 4d). With increasing F₄-TCNQ concentration, the threshold voltage was found to shift towards more positive gate-voltage values in line with the occurrence of *p*-type doping.

Besides PL and charge-transport measurements, Raman spectroscopy is also a versatile tool for studying doping effects in TMDs.²²⁷ The two main Raman-active phonon modes of 2H-TMD crystals are A_{1g} and E_{2g}^1 , which correspond to out-of-plane vibrations of chalcogen atoms and in-plane vibrations of chalcogen and transition metal atoms, respectively.²²⁸ Density functional theory (DFT) calculations and symmetry arguments predict that for MoS₂, the A_{1g} phonon mode is more sensitive to the electron doping than the E_{2g}^1 due to a stronger electron-phonon coupling in the out-of-plane A_{1g} vibration.²²⁷ Raman spectra of few-layer MoS₂ sheets were measured after “decoration” with *n*-type and *p*-type dopant molecules, as illustrated in Fig. 5.⁸⁷ For the *n*-type dopant (2-Fc-DMBI)₂ — *i.e.* 2-ferrocenyl N,N'-dimethylbenzimidazoline radical, inset of Fig. 5b — the A_{1g} peak of MoS₂ red-shifts by ~1 cm⁻¹ and the peak broadens ($\Delta FWHM \approx 1.4$ cm⁻¹), whereas the E_{2g}^1 mode remains almost unchanged ($\Delta\nu < 0.2$ cm⁻¹, Fig. 5b). In contrast, for *p*-type dopants such as tris(4-bromophenyl)ammoniumyl hexachloroantimonate (“Magic Blue”, Fig. 5d) both A_{1g} and E_{2g}^1 peak blue-shift ($\Delta\nu \approx 0.5$ cm⁻¹) and the peak sharpens ($\Delta FWHM \approx -0.4$ cm⁻¹). The effects of molecular physisorption doping on the Raman spectra of MoS₂ nanosheets are similar to those induced by electrostatic gating in FET structures.²²⁷ With the increasing gate voltage (electron

doping), the A_{1g} peak red-shifts and the peak broadens. This demonstrates that molecular physisorption influence phonon vibrations by modifying electron-phonon interactions. Furthermore, the shift of the A_{1g} Raman peak is proportional to the doping concentration,²²⁷ which is quite useful to probe the doping level in TMDs.

Numerous molecules have been exploited to tune the properties of TMDs.^{25, 36} Among these, we discuss a class of metallophthalocyanine molecules — indicated as MPc, where M is the metal centre (*e.g.* NaPc, MgPc, TiPc, FePc, NiPc, CuPc, PtPc, *etc.*) — which are currently attracting attention for doping TMDs due to their metal-centre dependent redox potential.⁹⁹ A schematic illustration of a MPc molecule physisorbed on a TMD sheet is provided in Fig. 6a. The planar structure of π -conjugated rings results in a flat-lying MPc/TMD configuration. Based on the positions of the band edges of TMDs with respect to the redox potential of MPcs, it is possible to predict the direction of the charge transfer between the TMDs and the MPc molecules.⁹⁹ For example, the redox potential of NiPc (MgPc) is located below (above) the CBM of MoSe₂ (Fig. 3). Upon light irradiation, photo-excited electrons in the conduction band of MoSe₂ can transfer to NiPc molecules, which provide a non-radiative recombination pathway that severely degrades the PL quantum yield of monolayer MoSe₂ (Fig. 6b). In contrast, no significant changes can be observed in the PL spectra of MgPc-treated MoSe₂ (Fig. 6c).⁹⁹ Physisorbed MPc molecules can be effectively used for tuning the charge-carrier density in ultrathin TMD sheets. For instance, NaPc induces *n*-type doping in MoS₂ whereas FePc and CuPc result in *p*-type doping.⁸⁹ Interestingly, the charge-carrier density in hybrid MPc/TMD systems depends on the work function of the MPc metal centre, which can therefore be chosen *ad hoc* for achieving the desired level of doping. It is worth noting that MPc/MoS₂ FETs were found to be stable for at least two weeks after doping, despite the lack of any encapsulation layer. Finally, physisorbed MPc molecules have been investigated for

passivating electronic defects, as well as for engineering surface states in defective monolayer MoS₂.²¹⁷

The effects of organic dyes on the optoelectronic properties of TMDs were recently explored.^{218, 229} In particular, perylenediimides and tetraphenyl porphyrins allowed increasing the conductivity of bottom-contact back-gate photodetectors based on relatively thick MoS₂ sheets (approximately 10-layers)²¹⁸ Such an increase was ascribed to the *n*-type doping induced by physisorbed molecules.

All these results demonstrate the possibility to control the charge-carrier doping in TMDs by molecular physisorption. However, further research is required to improve the stability of the charge transport properties in hybrid TMD-molecule systems, *e.g.* by developing suitable encapsulation techniques to prevent desorption or eventual decomposition of molecules during device operation and storage. Towards this goal, novel approaches are being explored. For instance, Yu *et al.*²¹⁵ reported on the use of mixtures of poly(methyl methacrylate) (PMMA) and F₄-TCNQ for simultaneously doping and encapsulating few-layer WSe₂ FETs.

2.2 Molecular engineering of the top and bottom TMD surface

In this section, we highlight how molecular decoration enables significant engineering of TMDs also in the absence of strong covalent interactions and significant charge transfer. When organized in continuous and homogeneous layers, even inert molecules can modify the TMD optoelectronic properties, by acting as passivating/encapsulating agents²³⁰ or by interacting through (ordered) dipolar fields.³⁹

In particular, the bottom TMD surface has been modified through a highly controllable molecular tuning of the physico-chemical properties of the substrate surface. This goal was achieved by inserting polymers or chemisorbed SAMs between the substrate and the TMDs. Instead, the top TMD surface is affected by the presence of highly ordered physisorbed layers

composed of functional molecules. We highlight that whenever ordered monolayers are employed, the collective interaction between molecules and 2D materials is determined by the nanoscale molecular ordering. Precise control over the molecular arrangement at the nanoscale can thereof be exploited to finely tune the TMD optoelectronic properties. In this regard, the electrical and optical characterization of TMD/molecules systems should be ideally complemented by scanning tunnelling microscopy (STM) investigations, which offers the possibility to explore molecular adsorption with sub-molecular structural and functional resolution.²³¹⁻²³⁴ In this way, STM could provide precious insights into the molecular-scale mechanisms leading to macroscopic effects, permitting not only to control the nanoscale assembly, but also to guide in the program and design of molecular units exhibiting the desired cooperative or collective effects. This possibility will be discussed in more detail in the conclusion section.

TMDs on polymers and functional SAMs. Polymers have often been employed as dielectric substrates for TMDs,^{205, 206, 235-237} in view of their mechanical flexibility that makes them compatible with bendable and stretchable electronics.^{47, 238, 239} As compared to conventional SiO₂, dielectric polymer films can be remarkably different in terms of surface roughness, dielectric permittivity and phonon vibrations.^{205, 240, 241} Molecular design can be exploited to tailor the physico-chemical properties of polymeric surfaces, *e.g.* enabling a precise tuning of the surface energy.²⁴² Hereafter, we present a few examples in which polymer-modified substrates result in a significant improvement of the (opto)electronic properties of TMDs.

Fig. 7a displays the general scheme of a typical FET based on TMD sheets deposited onto a dielectric polymer substrate. By using this architecture, Chamlagain *et al.*²⁰⁵ demonstrated that the room-temperature field-effect mobility of multilayer (5-15 nm thick) MoSe₂ FETs on parylene (100-150 cmV⁻¹s⁻¹) was systematically higher than in the case of equivalent devices on SiO₂ (~50 cmV⁻¹s⁻¹, Fig. 7b). The authors attributed such substrate dependent mobility to

different phonon vibrations at the SiO₂ and parylene surfaces. In particular, the scattering with polar optical phonons originating from the substrate limits the mobility of MoSe₂ on SiO₂, while it is nearly absent for MoSe₂ on parylene.²⁰⁵ Alternative explanations for the measured effects include the polymer-mediated passivation of charged impurities on the SiO₂ surface and a partial leveraging of the TMD layer due to the polymer roughness, which helps the removal of adsorbate molecules trapped below the bottom TMD surface during vacuum annealing. Similarly, the electronic performances of multilayer MoS₂ on PMMA were found to be higher than those on SiO₂. Remarkably, in the case of MoS₂ on PMMA not only high *n*-type mobility was measured (up to ~470 cm²/Vs) but also *p*-type mobility (up to ~480 cm²V⁻¹s⁻¹), resulting in almost ideal ambipolar characteristics. The different electronic behavior of MoS₂ on SiO₂ and PMMA was attributed to short range disorder at the TMD/SiO₂ interface (*e.g.* roughness scattering).²³⁶

In a recent study, Liu *et al.*²⁰⁶ found that the PL spectrum of MoS₂ onto the fluoropolymer CYTOP closely resembles that of self-standing MoS₂ with a narrow and strong PL peak at the region of A exciton and without trion peak (Fig. 7c). A similar effect was observed for WS₂.²⁰⁶ FETs fabricated on MoS₂ monolayers on CYTOP also showed lower intrinsic *n*-type doping and higher mobility than those fabricated on SiO₂. In view of these results, the authors conclude that CYTOP is an ideal substrate for TMDs, on account of its very low surface energy, low surface trap densities and low permittivity. By taking full advantage of the polymeric substrate, the authors demonstrate a giant bandgap renormalization in back-gated MoS₂ and WS₂, which manifests itself as a sizeable gate-induced modulation of PL and differential reflectance (Fig. 7d).²⁰⁶

These examples show how TMD/substrate interactions, which remarkably influence the charge-transport properties of TMDs,²⁴³ can be tuned by making use of polymeric substrates, thereby offering a valuable strategy to engineer TMD-based devices.

Similarly, the physico-chemical properties of the substrate can be tailored by using functional SAMs chemisorbed on solid substrates.²⁴⁴ The molecules employed to generate such architectures possess (i) an anchoring group that promotes the chemisorption onto the substrate, (ii) a molecular backbone that stabilizes the packing *via* side-to-side molecular interactions, and (iii) a functional headgroup that ultimately determines the physico-chemical characteristics of the exposed surface.²⁴⁵ TMDs can be deposited onto SAM-modified surfaces (*e.g.* Fig. 8a) and they display different properties depending on the molecular headgroups in the SAM. We point out that while SAMs are covalently bound to the substrate, TMD sheets are physisorbed onto SAMs and their interaction is mediated by relatively weak van der Waals forces. Crucially, non-covalent interactions among adjacent molecules forming the SAM endow high crystalline order with molecules oriented edge-on with respect to the substrate plane.²⁴⁴ In this way, the ordered nanoscale arrangement ensures that single-molecule dipoles sum up, collectively generating significant electric fields. Therefore, when TMDs are exfoliated onto SAM-decorated substrates, they experience an electric field effect analogous to that generated by a constant non-zero gate voltage. As a result, highly ordered SAMs of high-dipole molecules can introduce significant shifts in the Fermi level of TMDs,⁸⁴ resulting in doping effects that are mediated by purely electrostatic interaction, even in the absence of significant charge transfer. The two doping mechanisms – *i.e.* charge transfer^{82, 87} or dipolar interactions^{87, 246} – are often concomitant, and it is not always possible to completely disentangle one from the other.^{87, 92}

Experimentally, the possibility to modulate the charge carrier concentration *via* SAMs was demonstrated in a study of the optoelectronic characteristics of mechanically-exfoliated MoS₂ sheets deposited onto different SAMs.⁸⁴ The authors modified the SiO₂ substrate employing SAMs composed of alkanes exposing an anchoring silane group and different functional headgroups. In particular, SAMs of three silane agents characterized by different dipole

moments and polarities were employed: octyltrichlorosilane (OTS, CH₃-SAM), 3-(trimethoxysilyl)-1-propanamine (APTES, NH₂-SAM), and trichloro-(1H,1H,2H,2H-perfluorooctyl)silane (FOTS, CF₃-SAM), as shown in Fig. 8a. The arrangement of the different molecules, which plays a fundamental role in the determination of the measured effects, was indirectly inferred on the basis of the surface energy of the SAMs, as measured by water contact angle. The effect of the different molecular dipoles on the optoelectronic properties of MoS₂ was investigated by a combination of Raman spectroscopy, FET fabrication and characterization, as well as Kelvin probe force microscopy (KPFM) measurements. Fig. 8b shows the electrical characterization of FETs based on a few-layers MoS₂ fabricated on the different SAMs. The FOTS SAM was found to induce a positive shift of the threshold voltage, *i.e.* it introduces *p*-type doping. On the other hand, the APTES SAM was found to introduce a shift of the threshold voltage towards more negative gate values, *i.e.* introduce *n*-type doping. Through KPFM, the authors showed that the position of the Fermi level of monolayer MoS₂ could be modulated in a range of more than 0.45 eV by the electrostatic interaction with FOTS and APTES. Finally, minor effects on the threshold voltage were observed for the OTS SAM as compared to the bare SiO₂ substrate, indicating minor doping.⁸⁴ These results were explained on the basis of the different orientation of the (well-aligned) molecular dipoles, which point towards opposite directions for FOTS and APTES. Instead, the relatively low dipolar moment of CH₃ did not induce significant doping on MoS₂. Nevertheless, even alkyl SAMs have interesting effects on the optoelectronic properties of TMDs. Recently, Ajayi *et al.*²³⁰ measured an ultranarrow low-temperature PL linewidth in MoSe₂ (approaching the intrinsic limit) thanks to an effective substrate passivation achieved *via* alkyl SAMs. In particular, a 6-meV-wide PL peak was measured for MoSe₂ on the alkyl SAM, in contrast to the broader 9-meV peak of MoSe₂ on SiO₂. Additionally, the presence of the alkyl SAM also affected the optical characteristics of MoSe₂

encapsulated in BN (BN/MoSe₂/BN), which exhibited broader PL on the bare SiO₂ (3 meV) rather on the SAM-passivated surface (2 meV).

Theoretically, it was predicted that the presence of SAMs exposing a polar headgroup (both –CH₃ and –CF₃) anchored onto metal electrodes could promote the charge injection into MoSe₂, converting Schottky metal-semiconductor junctions into nearly Ohmic contacts.⁹⁵ These studies show how SAM engineering represents a straightforward approach to control the charge-carrier polarity enabling the fabrication of *p-n* junctions and complementary logic devices.

Taking a step further, a thorough choice of the molecules composing the SAMs makes it possible to confer unique SAM-derived capabilities to TMDs. This possibility was demonstrated by depositing MoS₂ onto a photoswitchable SAM composed of a thiolated photochromic azobenzene (AZO) moiety ((E)-6-(4-(phenyldiazenyl)phenoxy)hexane-1-thiol, HS-C₆AZO) chemisorbed on a gold substrate (Fig. 8c).^{222, 247} AZO are photochromic molecules which can be switched between a *trans* and a *cis* isomer upon light irradiation at different wavelengths (Fig. 8c).²⁴⁸ When AZO molecules self-assemble forming ordered chemisorbed monolayers on metals, the photoswitch is accompanied by a modification of the surface energetics,²⁴⁹⁻²⁵¹ which is in turn reflected by a change of the optical properties of MoS₂ monolayers.²²² In particular, lower (higher) PL intensity was measured when the AZO-SAM was in the *trans* (*cis*) state, which was explained in terms of different molecule-induced doping in the two cases (Fig. 8d).

The same Au/AZO-SAM/MoS₂ stack was exploited to demonstrate photo-switchable vertical diodes, in which the current flowing vertically through the stack was measured by contacting the MoS₂ sheet with a conductive tip in an atomic force microscope (AFM). With the AZO-SAM in the *trans* state, a rectifying diode-like trace was measured with turn-on voltage close to 0.5 V (Fig. 8e). After photo-isomerization to the *cis* state, the *I-V* traces showed a

suppression of the rectification, while the diode-like characteristics could be partially recovered by switching back the AZO-SAM to the *trans* state. These experiments demonstrate the possibility to modify reversibly the energetics of TMDs thanks to a unique molecular capability, such as the switching of photochromic molecules. In this regard, hybrid systems composed of functional molecules/TMDs represent an entirely new class of materials characterized by unique properties different from those of the isolated components even in the absence of covalent bonds.

Physisorbed crystalline monolayers on TMDs. While in the previous section we have discussed the case of molecular tailoring of the *bottom* TMD surface, here we focus on the effect of non-covalent molecular modification of the *top* TMD surface. Supramolecular interactions, in particular of van der Waals type, can drive the formation of physisorbed crystalline monolayers of molecules onto TMDs, in which the molecular dipoles self-align,^{81, 252, 253} thereby giving rise to electrostatic effects analogous to those discussed in the previous section. This possibility was demonstrated by the works by Kang *et al.*,^{39, 86} in which ordered molecular layers were physisorbed onto the top TMD surface to induce non-degenerate doping effects (Fig. 9a). In contrast to the case of TMD onto SAM-modified substrates, in the case of top surface modification it was possible to measure the electrical characteristics of the TMDs before and after the formation of the molecular layer, enabling a precise estimation of the doping introduced by the molecular layer. Interestingly, the molecules investigated for the modification of the top surface of few-layer MoS₂ and WSe₂ (ODTS and APTES, Fig. 9a) bear the same functional groups used for tailoring the bottom substrate *via* SAM chemisorption (Fig. 8a).^{39, 86} Fig. 9b displays the effect of ultrathin ODTS layer on the electrical characteristics of WSe₂. In this case, a relatively small shift of the threshold voltage towards more positive values was measured, indicative of *p*-type doping. An analogous *p*-type doping was observed for ODTS onto MoS₂, while the layer of APTES molecules was

observed to induce *n*-type doping on both WSe₂ and MoS₂ (Fig. 9c). These results are qualitatively similar to those obtained for the same molecules at the bottom of TMDs, and similarly were explained by considering that the doping effects were mediated by molecular dipoles, which effectively changed the surface energetics.⁸⁶ In particular, it was proposed that the molecular assemblies on the top and at the bottom are specular, so that the TMD layer is effectively affected by analogous electric fields.

We would like to point out that the molecular dipoles orientation is dictated by the molecular arrangement. The fact that analogous doping effects are measured also on different TMDs (MoS₂ and WSe₂, Fig. 9c) indicates that the arrangement of a given molecule on the sub-nanometre scale on different vdW surfaces is the same. Indeed, analogous van der Waals forces drive the formation of the same assembly on the inert, chemically similar van der Waals surfaces of layered materials.^{252, 253} Therefore, one can assume that the doping induced by the assembly of the same molecule on different TMDs is analogous, since the assembly is typically the same.²⁵²

We mention that the presence of a molecular film on the surface of TMDs can be exploited not only to modify the properties of TMDs at a fundamental level, but also to enable technologically relevant application. As an example, in the work discussed in Fig. 9a-c, it was found that the molecules improved the photoresponsivity and detectivity of TMD-based photodetectors.³⁹ Moreover, highly ordered molecular monolayers adsorbed either above or below TMDs have been employed in combination with ultrathin inorganic layers as ultrathin gate dielectrics for flexible electronics.^{91, 254} The resulting transistors operating at low voltage showed remarkable subthreshold swing (< 80 mV/dec), limited hysteresis and high breakdown field.

3. Chemical treatments for optimizing optical processes in 2D TMDs

The modifications in the optical properties of TMDs discussed in Section 2 arise from changes in the charge-carrier density induced by molecular layers.^{102, 103, 209, 255} Here, we discuss a few recent experiments showing how appropriate chemical treatments can be used to optimize the photoluminescence (PL) emission in 2D TMDs in a way that cannot be explained by electronic doping, and which involves the passivation of surface defects.

Typically, the doping-induced PL modulation is relatively weak for monolayer MoS₂, with *p*-dopants introducing up to a three-fold PL increase.²⁴⁹ In contrast, Amani *et al.*⁹⁷ reported on a two-orders-of-magnitude increase in the PL of chemically-treated MoS₂, reaching near-unity quantum yield. In particular, the authors demonstrated that a treatment with the nonoxidizing organic superacid bis(trifluoromethane)-sulfonimide (TFSI, inset in Fig. 10a) determined an up-to-190-fold increase in the PL intensity without significant changes in the spectral shape (Fig. 10a). PL maps of the same 2D MoS₂ sheet measured before and after the superacid treatment revealed that the increase was spatially homogeneous (Fig. 10b). Remarkably, it was found that at low excitation intensity ($<10^{-2}$ Wcm⁻²), the PL quantum yield approached ~ 1 , *i.e.* almost the totality of the incoming photons were re-emitted (Fig. 10c). Following the discussion in Section 2, one might expect the PL boost to be mediated by *p*-doping, since TFSI is a strong electron acceptor.²⁵⁶ Through the comparative electrical characterization of a 2D-MoS₂ FET before and after the superacid treatment, the authors demonstrated that TFSI would not induce significant *p*-type doping. Instead, the passivation of surface defects was put forward as main effect leading to the increased PL.⁹⁷ Indeed, the low PL quantum yield of (untreated) MoS₂ at low excitation power is typically attributed to defect mediated non-radiative recombination;⁷⁰ hence the near-unity quantum yield of the treated samples indicates a defect passivation. However, the exact mechanism through which defects are passivated is not entirely understood. More recent studies have shown that the

same superacid treatment could be successfully applied to CVD-grown MoS₂,⁹⁸ and that its effect could be made stable by encapsulation with a CYTOP film.²⁵⁷ Moreover, it was demonstrated that not only the PL of MoS₂ but also that of WS₂ is boosted by the TSFI treatment.⁹⁶ On the contrary, the TSFI treatment does not enhance the quantum yield of Se-based TMDs, such as WSe₂ and MoSe₂.⁹⁶ An STM investigation of the defects in sulfide- and selenide-based TMDs suggested that the different effects of the TSFI treatment could be explained by the distinct nature of the defects in TMD selenides and sulfides.⁹⁶ In particular, the defects found on sulfide surfaces were either structural defects or acceptor impurities, whereas those found on selenide surfaces were mainly donor impurities.⁹⁶

Similarly to the case of TFSI, an acid-mediated sulfur vacancies self-healing was put forward in a recent experiment in which MoS₂ was placed in contact with non-oxidizing acid poly(4-styrenesulfonate) (PSS).²⁵⁸ In this case, self-healing was accompanied by a *p*-type doping effect and a rather limited PL increase (two-fold).

A similar acid based self-healing of defects was demonstrated for Se-based TMDs. In particular, it was demonstrated that the PL of CVD-grown MoSe₂ could be increased *via* treatment with hydracids.¹⁰⁰ The highest effect was found for hydrohalic acid (HBr), which caused a 30-fold increase in the PL of MoSe₂ (see Fig. 10d-e). In this case, two concomitant mechanisms were identified to account for the measured effect: (i) an induced *p*-type doping, as inferred from a Raman characterization and (ii) an acid-mediated structural healing, inferred on the basis of low temperature PL spectra and XPS characterization. In particular, for untreated MoSe₂ sheets, the PL spectrum was dominated by a rather broad PL peak at ~1.56 eV, which was ascribed to the radiative emission of excitons bound to defects (Fig. 10f). Instead, after HBr treatment, the low temperature PL became more structured, with two sharper peaks corresponding to the neutral exciton and trion peak. The decrease in the relative intensity of the defect-related peak indicated the HBr-induced defect healing in MoSe₂. In

particular, the authors found spectroscopic evidences of undesired oxidized Se in the as-grown CVD MoSe₂, and concluded that HBr effectively passivates these defects by replacing oxidized Se defects (Se-O) with Br, which covalently binds to Mo atoms.¹⁰⁰

These experiments indicate the potential of acid treatments to passivate defect-mediated recombination pathways in TMDs, leading to almost-ideal optical properties. Therefore, the chemically treated ultrathin TMDs might enable the demonstration of optimized optoelectronic devices, such as high-performance light-emitting diodes, lasers and solar cells.

4. Covalent functionalization *via* defect and phase engineering

During the last five years, several works have been published on the covalent functionalization of ultrathin TMDs, mainly focusing on solution-processed MoS₂ nanosheets produced *via* ion intercalation (1T/1T' phase)^{259, 260} or ultrasonication (1H/2H) methods.^{110, 261}

These studies will be presented in Section 5, which is dedicated to solution-based approaches for the preparation of inks of functionalized TMDs. Here, we will review those investigations carried out on substrate-supported nanosheets, which aimed at “decorating” the top surface of the 2D materials with molecules through bond-formation processes. As mentioned in the introduction, MoS₂ is the prototypical element of the TMD class,¹⁹ so that pioneering explorations in this research area have been carried out mostly on this promising 2D semiconductor. However, the concepts and strategies described in the following can be easily extended to other ultrathin TMDs, in particular MoWSeS materials, which have structural and physico-chemical properties similar to those of MoS₂. Indeed, all MoWSeS crystals exhibit a stable 1H/2H semiconducting phase^{9, 150} and their surface lacks dangling bonds, a fact that makes the covalent functionalization of the basal plane a challenging objective.^{80, 110, 200, 260}

In 2014, Azcatl *et al.*²⁶² reported on a non-disruptive method for the functionalization of MoS₂ based on exposure to UV-ozone. The latter induces the formation of an oxygen layer on

the surface of the 2D semiconductor, which can be conveniently exploited as a seed layer for the growth of high-quality dielectric films by atomic layer deposition (ALD).^{262, 263} Noticeably, the structural and the electronic properties of MoS₂ were not found to be altered by the UV-ozone treatment, which supported the finding of weak bonding interactions between oxygen and sulfur atoms.^{262, 263}

Nowadays, two major strategies are being explored towards the strong covalent or coordinative bonds between TMDs and atomic or molecular adlayers. The first involves the activation/optimization of the chemical reactivity of the nanosheets' surface *via* the controlled generation of point defects, such as chalcogen vacancies. In such a way, dangling bonds are generated locally at defect sites, enabling the formation of chemical bonds between the defective surface and molecules with *ad hoc* functional groups. The second method deals with the phase tunability of TMDs,¹³⁵ which allows for the reversible conversion of the electron-rich and easy-to-functionalize polytype (1T/1T') into the more inert semiconducting polytype (1H/2H).⁸⁰ As we shall see, the latter approach enables preparing functionalized 1H/2H nanosheets through phase-conversion processes triggered by chemical or thermal stimuli.⁸⁰

4.1 Engineering chemically-active defects

Numerous techniques have been used to engineer defects, such as chalcogen vacancies, in the basal plane of ultrathin TMDs, among which electron irradiation,²⁶⁴⁻²⁶⁷ thermal annealing,^{88, 268, 269} electrochemical generation,¹⁸⁶ plasma treatments,^{185, 270-273} as well as physical bombardments with charged particles, including ions of argon,^{109, 274-276} helium,²⁷⁷⁻²⁷⁹ manganese,²⁸⁰ α particles (He^{2+})¹⁵⁹ and swift heavy ions (*e.g.* Xe/Ta, $E \approx 80\text{-}100$ MeV).²⁸¹ Moreover, chalcogen vacancies have been systematically generated during the growth/synthesis process *via* non-equilibrium CVD methods,²²³ as well as through hydrothermal synthetic strategies.²⁸² Theoretical calculations have also been carried out to corroborate experimental results and elucidate the structures/properties of the defects

produced with such techniques, *e.g.* in the case of electron irradiation (refs 68, 267) and ion bombardment (ref. 283). In 2012, Komsa *et al.*⁶⁸ carried out a joint theoretical and experimental investigation on the effects of electron irradiation on the atomic structure of ultrathin TMDs. In particular, they observed the formation of sulfur vacancies (SV) in 1H-MoS₂ sheets exposed to an electron beam ($E \approx 80$ keV) within a high-resolution transmission electron microscope (HRTEM). The possibility of filling the SVs with donor and acceptor impurities — with the objective of introducing doping — was supported by calculations of the formation energy of substitutional defects. Experimentally, *in situ* HR-TEM studies provided evidence for the occurrence of SV filling (see Fig. 11a-c), though it was not possible to identify the type of the impurity involved in the process. Subsequent theoretical works were carried out on substitutional doping of TMDs, and various strategies have been proposed for adding novel functionalities to MoS₂ by means of magnetic, rare-earth and chalcogen dopants, as well as molecular ions.^{284, 285} More recently, a combined TEM and Raman-spectroscopy study (ref. 265) allowed establishing a correlation between the density of SVs in electron-irradiated MoS₂ nanosheets and the energies of the main Raman-active phonon modes (E_{2g}^1 and A_{1g}), thereby providing an indirect means for quantifying SVs in ultrathin MoS₂.

In 2013, Ma *et al.*²⁷⁴ showed that low-energy ($E \approx 500$ eV) argon-ion irradiation of monolayer MoS₂ results in the controlled generation of SVs, as evidenced by X-ray photoemission spectroscopy (XPS) studies, see Fig. 11d. In contrast to their electron counterpart, ion beams have relatively larger diameters (~ 100 s μm) and can be rastered over centimetre-scale large areas in relatively short time, enabling the fast processing of wafer-scale CVD-grown films. Although this was the first study on a truly 2D semiconductor, it should be mentioned that several investigations have been carried out in the past on the effects of argon ion bombardment on bulk TMD crystals.^{187, 286-291} In 1972, Williams *et al.*²⁸⁶ performed low-energy ($E \approx 300$ eV) argon-ion bombardment on the surface of various layered chalcogenide

materials, among which MoS₂, NbSe₂, ZrS₂, MoTe₂, TiTe₂ and SnS₂, revealing — in most of the cases — a significant enhancement of the reactivity of the basal plane in the presence of oxygen species. This was attributed to the pitting and faceting of the surface upon ion bombardment, leading to the increase of the effective surface area of the sample.²⁸⁶ However, little was known about the structure of the defects. Two years later, Feng and Chen²⁸⁷ conducted XPS measurements on bulk MoS₂ crystals irradiated with argon ions of ~300 eV, and observed the formation of islands of metallic molybdenum along with a decrease in the sulfur content. The authors hypothesized that sulfur atoms, which have a mass similar to that of argon, could be ejected more efficiently in comparison to heavier molybdenum atoms, thereby enabling a selective sputtering process. Nowadays, bombardment with argon-ion beams is a common and established method for engineering chalcogen vacancies in ultrathin TMDs,^{274 109, 275} together with similar techniques based on plasmas of argon ions.^{185, 273} In 2016, Li *et al.*¹⁸⁵ showed — both theoretically and experimentally — that SVs generated *via* argon plasmas lead to the activation of the basal plane of 1H-MoS₂ monolayers for hydrogen evolution reaction (HER), which could be further optimized through the application of in-plane strain. The HER activity of 1H-MoS₂ sheets has also been enhanced through electrochemical desulfurization processes (ref. 186), which allowed tuning the density of SVs by changing the applied desulfurization potential. Additionally, complementary thermal approaches have been developed for the generation of SVs, such as annealing in ultra-high vacuum ($p \approx 10^{-9}$ torr, $T \geq 200$ °C)²⁶⁸ or in air ($T \approx 250$ °C).⁸⁸

Having a high density of chemically-active chalcogen vacancies is desired for the purpose of functionalization, but it can also be very detrimental in other perspectives, *e.g.* for applications in (opto)electronic devices. In a recent work, the effects of ion-beam induced SVs on the optical, vibrational, as well charge transport properties of mechanically-exfoliated monolayer MoS₂ have been investigated (ref. 109). The unencapsulated channel of back-gated

monolayer FETs has been irradiated with low-energy ($E \approx 500$ eV) argon ions, as shown in Fig. 11e. This allowed monitoring the evolution of the electrical characteristic of the devices with increasing ion dose, as shown in Fig. 11f and g. Noticeably, the experiments were carried out under inert atmosphere to minimize possible oxygen chemisorption at defect sites, which could affect the electronic structures/properties of semiconducting TMDs.²⁹² The results reported in this work¹⁰⁹ provided a guideline for the trade-off choice between density of SVs suitable for chemical functionalization and device performance, in terms for instance of charge-carrier mobility and $I_{\text{on}}/I_{\text{off}}$ switching ratio in FETs.

4.2 Repair and functionalization of defective TMDs

In the last few years, various research groups have explored the possibility of repairing/functionalizing defective MoS₂ nanosheets with small organic molecules carrying thiol headgroups.^{88, 109, 293} Noticeably, the reactivity of SVs with thiol molecules has been investigated since the 1970s, mainly due to the widespread use of MoS₂ as a catalyst for hydrodesulfurization to remove sulfur from oil.²⁹⁴ The adsorption and decomposition of alkanethiols on defective MoS₂ surfaces have been previously investigated, for instance in the case of butanethiol,²⁹⁴ ethanethiol,²⁹⁵ methanethiol²⁹⁶ and dodecanethiol.¹⁸¹ In 2012, Makarova *et al.*¹⁸¹ reported a STM study supporting the hypothesis of bond formation between thiol groups and unsaturated molybdenum atoms at SV sites. In particular, two thiol derivatives — namely (3-mercaptopropyl)-trimethoxysilane (MPS) and dodecanethiol — were adsorbed to the surface of bulk 2H-MoS₂ crystals, as schematized in Fig. 12a. The density of molecules was found to match the typical density of SVs in common MoS₂ samples, suggesting a possible chemisorption of the thiol molecules at SV sites. Interestingly, the authors observed that both thiol derivatives could be easily desorbed from the surface by applying electrical stimuli with the STM tip, a phenomenon that was ascribed to the tip-induced dissociation of the S-C bond (Fig. 12b). Remarkably, such a process was found to

lead to the filling/repairing of the SVs. Inspired by these results, Yu *et al.*¹⁸² developed a thiol-chemistry approach with the aim of healing defects and improving the charge-transport properties of ultrathin sheets of MoS₂. The treatment consists in the immersion of SiO₂/Si substrates carrying mechanically-exfoliated MoS₂ flakes in a solution of MPS in dichloromethane, followed by thermal annealing ($T \approx 50$ °C, 20 min) to induce the scission of the S-C bond and remove the excess MPS molecules. Density functional theory calculations (DFT) were carried out to assess the kinetics of the reaction, shown in Fig. 12c. The effective reduction of the number of SVs was supported by a statistical analysis of HR-TEM images acquired from as-exfoliated and treated samples, which revealed a decrease in the average SV density from $\sim 6 \times 10^{13} \text{ cm}^{-2}$ to $\sim 1.6 \times 10^{13} \text{ cm}^{-2}$. Thanks to their trimethoxysilane groups that chemisorb on SiO₂, MPS molecules have also been used for the formation of SAMs on the oxidized silicon substrates. In this case, the molecules expose their thiol groups towards the overlying MoS₂ nanosheets, thereby providing — upon annealing — an opportunity for healing SVs in the bottom surface. The effects of such thiol-chemistry treatments on the electrical properties of back-gated MoS₂ FETs are reported in Fig. 12d and e. Upon repairing SVs in the top and bottom surfaces, the field-effect mobility increases up to $\sim 80 \text{ cm}^2 \text{V}^{-1} \text{s}^{-1}$ (at room temperature), which is one of the highest values achieved so far using back-gated monolayer MoS₂ FETs on conventional SiO₂/Si substrates.²⁹⁷ A follow-up work by Cho *et al.*²⁹³ focused on the passivation of SVs in multilayer MoS₂ sheets (2-11 nm thick) with alkanethiol molecules. The healing procedure, based on the immersion of the samples into an ethanol solution of hexadecanethiol (or octanethiol) molecules, did not include the annealing step previously used to promote the scission of the S-C bond and the removal of not-chemisorbed molecules. As a result, the electrical current and the charge-carrier mobility in FETs were found to decrease. This was ascribed to trap states associated with alkanethiol molecules chemisorbed at SVs. Sim *et al.*⁸⁸ adopted a similar approach aiming at introducing a stable

doping in few-layer MoS₂ nanosheets (2-4 layer thick) *via* chemisorption of thiol molecules carrying donor or acceptor groups, see Fig. 12f. After immersing the samples in ethanol solutions of mercaptoethylamine (NH₂-terminated thiol, MEA) and 1H,1H,2H,2H-perfluorodecanethiol (CF₃-terminated thiol, FDT), the authors performed a mild annealing under inert atmosphere (100 °C, 30 min) and an abundant solvent rinsing to remove unbound molecules. Such a treatment resulted in *n*-doping in the case of MEA ($\Delta n \approx 3.7 \times 10^{12} \text{ cm}^{-2}$) and *p*-doping in the case of FDT ($\Delta n \approx -7.0 \times 10^{11} \text{ cm}^{-2}$), which was supported by multiple techniques, including PL spectroscopy, XPS and electrical measurements. In FETs, the doping effect appeared more evident after an additional annealing step ($T \approx 150 \text{ °C}$, 10 min) that served for removing water and oxygen molecules that are known to behave as electron acceptors.²⁹⁸ The resulting transfer characteristics of pristine (black) and doped (red and blue) few-layer MoS₂ FETs are shown in Fig. 12g. More recently, short-chain alkanethiols, such as butanethiol, have also been used to heal SVs introduced *via* low-energy ion irradiation in the channel of monolayer MoS₂ FETs (ref. 109). In this case, a vapour-phase deposition process — carried out strictly under inert atmosphere without other external influences — enabled a significant recovery of the electrical characteristics of ion-irradiated FETs, confirming the occurrence of defect healing by thiol molecules.

The results discussed so far showed that repair (involving the dissociation of the S-C bond) and functionalization of SVs *via* chemisorption of thiols are two possible outcomes. This aspect has been investigated theoretically by two groups,^{183, 184} who showed by means of DFT calculations that both reactions can actually occur. Nevertheless, the mechanisms involved might vary depending not only temperature but also on polarization effects associated with the molecule's decorating groups.¹⁸³ In the case of methanethiol, Förster *et al.*¹⁸⁴ found that repair is energetically most favourable over functionalization, whereas Li *et al.*¹⁸³ concluded that functionalization products are preferred due to slightly smaller energy barriers. However, it

should be noticed that such discrepancies may arise from different assumptions on the role of hydrogen in the reaction (adsorption/release), which is a debated argument in the chemistry of thiols at metal surfaces.^{244, 299-303} At this stage, more investigations are needed to identify the exact experimental conditions leading to the repair or functionalization of SVs.

The methods discussed above can be extended to other elements of the TMD family, in particular MoWSeS materials. For instance, the generation, healing and doping functionalization of selenium vacancies in ultrathin WSe₂ have been already reported in the last years.^{79, 271, 304} It is expected that 2D transition metal selenides could be similarly functionalized/repared with molecules carrying selenol headgroups,³⁰⁵ or once again repaired with thiol molecules — since sulfur and selenium are valence-isoelectronic elements — and this would allow developing 2D nanosheets with tunable chalcogen composition (*e.g.* WS_{2x}Se_{2(1-x)}).³⁰⁶ Despite problems associated to the limited chemical stability of selenol exposing molecules, novel investigations can be foreseen to explore the viability of these approaches.

4.3 Covalent functionalization *via* phase engineering

An alternative strategy for the covalent functionalization of ultrathin MoS₂ was reported in 2015 by Chhowalla and coworkers.⁸⁰ Such a method does not involve chemical reactions at defects, as previously discussed, but it rather exploits the phase tunability of TMDs¹³⁵ *via* chemical and thermal stimuli. It is known that chemical exfoliation with *n*-butyllithium leads to electron-rich nanosheets that contain ~65% of the metallic 1T/1T' polytype.^{141, 142} Interestingly, also the exposure of substrate-supported CVD MoS₂ sheets to *n*-butyllithium results in the change from the 1H to the 1T/1T' phase, as illustrated in Fig. 13b. This procedure was later shown to be also applicable to continuous polycrystalline MoX₂ films.³⁰⁷ This can be performed in a spatially-controlled manner, which is suitable for patterning metallic regions in a semiconducting 2D layer to develop low-resistance contacts for ultrathin

MoS₂ FETs.³⁰⁸ Chhowalla *et al.*⁸⁰ showed that metallic 1T/1T' nanosheets can be easily functionalized by subjecting them to methyl iodide and iodoacetamide electrophiles (see Fig. 13a), resulting in functional groups that are covalently bound to sulfur atoms. Here, the reaction is promoted by charge transfer between the electron-rich 1T/1T' MoS₂ and the organohalides, which allows for achieving a degree of functionalization of the order of ~30% (estimated by XPS). Atomic-resolution TEM studies carried out on functionalized nanosheets revealed that the original atomic structure with octahedral coordination is not altered by such a process (Fig. 13c). However, the functionalized 2D MoS₂ displayed optical properties remarkably different from those of its not-functionalized counterpart, including fluorescence emission (Fig. 13d). The latter indicates the opening of a semiconducting bandgap, which is a promising result proving the possibility of tailoring ultrathin TMDs by the combination of chemical and phase-engineering approaches.

The authors further showed that CVD monolayer MoS₂ films can be converted from 1H to 1T/1T' *via* *n*-butyllithium exposure; they can then be functionalized with electrophile molecules and subsequently re-converted into the 1H polytype by thermal annealing at $T \geq 300$ °C. Raman and XPS spectroscopy confirmed the occurrence of the semiconducting-phase recovery, whereas attenuated total reflectance Fourier transform infrared (ATR-FTIR) spectroscopy indicated that functional groups were still present on the surface of the 1H MoS₂ sheets. This technique — based on a two-step phase conversion process — is being regarded as a promising strategy for the covalent functionalization of semiconducting MoWSeS materials, which otherwise could not be functionalized in their pristine form due to the lack of dangling bonds. It is worth noting that the methods described above were applied also to WS₂ and MoSe₂, and are expected to be applicable to other TMDs.^{76, 80} In this research area, additional investigations are envisioned for tuning of the optical and electronic properties of ultrathin

TMDs *ad hoc* for applications, which can be achieved for instance by a careful choice/design of the electrophile molecules.

5. Functionalization of solution-processed TMD nanosheets

Functionalization can also be achieved on TMD nanosheets in the liquid phase by a number of strategies. The prerequisite is an efficient exfoliation in liquid to obtain colloidally stable dispersions. For TMDs, two main strategies exist which are referred to as chemical exfoliation (CE) and liquid phase exfoliation (LPE), respectively. Chemical exfoliation is based on the intercalation chemistry of TMDs first described in the 1970s.^{117, 309} Based on these early reports, the intercalation chemistry was explored in detail in the past century.³¹⁰ The current understanding of the chemical exfoliation is described in detail elsewhere^{15, 115} and is only briefly summarized here. The most commonly used technique is based on the reaction of bulk TMD powder with *n*-BuLi under inert conditions. Lithium is inserted between the layers followed by an electron transfer to the TMD resulting in an Li_xMX_2 salt. Due to the Coulomb repulsion between the negatively charged layers, efficient exfoliation down to predominantly monolayers can be achieved after agitation/sonication in water. After purification (removal of excess *n*-BuLi, reaction side products, unexfoliated TMD), a colloidal suspension of negatively charged nanosheets in water is obtained. Due to the excess charge, the MoWSeS-TMDs undergo a transition from the semiconducting 2H polytype (trigonal prismatic arrangement of chalcogen) to the metallic 1T/1T' polytype (octahedral arrangement of chalcogen, often distorted)¹¹⁵ — see Section 1.1. The metallic 1T-polytype is metastable and can be converted to the 2H-polytype on annealing or by ageing which is usually accomplished by flocculation of the TMDs if this takes place in the dispersion. Depending on the reaction conditions,^{260, 311, 312} defective nanosheets (chalcogen vacancies and/or holes on the basal plane) or mixtures of the 1T/2H-polytype are accessible.

A complementary technique that yields colloiddally stable dispersions of group VI-TMDs in the semiconducting 2H-polytype is liquid phase exfoliation (LPE). As summarized in detail in recent reviews,^{106, 313-317} this process involves sonication (or other forms of agitation such as shearing, ball milling) of the bulk powder in appropriate solvents or aqueous surfactant systems. A range of polymers (including biopolymers) can also be used as stabilizing agents in both aqueous and organic media. The energy or mechanical stress is required to overcome the van der Waals-type intersheet interaction and causes exfoliation of the bulk material into few-layers in the liquid with the nanosheet reaggregation prevented by the solvent/stabilizer. This process has first been demonstrated in 1989 *via* sonication of TMDs in water in an argon-hydrogen atmosphere.³¹⁸ However, in ambient conditions, water as a neat solvent (*i.e.* without additional stabilizers) is not a suitable solvent to stabilize the TMD nanosheets. It was first demonstrated by Coleman *et al.* in 2011,¹²² that solvents with solubility parameters matching the TMD can be used to obtain colloiddally stable dispersions under ambient conditions. Suitable solubility parameters to describe the solution thermodynamics are solvent surface tension or energy, Hildebrandt parameters or Hansen parameters. Typical solvent choices are N-methyl-2-pyrrolidone, N-cyclohexyl-2-pyrrolidone, dimethyl formamide or isopropanol to a lesser extent. Alternatively, as first demonstrated by the same group,³¹⁹ aqueous surfactant solutions can be used. The resultant nanosheet dispersion are highly polydisperse with respect to both layer number and lateral size, but size selection techniques have been developed to tackle this problem.³²⁰

Based on such nanosheet dispersions, numerous strategies have been developed to functionalize both basal plane and edges (Fig. 14). Due to the high surface area of the nanosheets, non-covalent functionalization *via* physisorption of various molecules, polymers (or noble metal nanoparticles) is commonly exploited. Note that numerous hybrid structures with other nanomaterials can be constructed in such a way as outlined elsewhere.³²¹ The most

widespread use of this non-covalent approach is to prevent nanosheets from reaggregation after LPE by adsorption of small molecules^{105, 319, 322-332} or (bio)polymers³³³⁻³⁶¹ (see Table 2).

The organic functional groups are believed to adsorb to the nanosheets *via* predominantly van der Waals interaction and dipole interactions can also occur.^{203, 362}

Similar to graphene, stabilization in the aqueous environment in the case of ionic surfactants is achieved mostly due to Coulomb repulsion that can be described within the Derjaguin-Landau-Verwey-Overbeek (DLVO) theory, even though steric hindrance can also play an important role.³⁶³ Unfortunately, it is extremely challenging to unravel experimentally how the surfactant adsorption occurs, or indeed how densely the surfactant is packed on the surface. Ref. 326 is highlighted in this regard, as it provides evidence that surfactant chains of the cationic amphiphile cetyltrimethylammonium bromide (CTAB) and the anionic surfactant sodium dodecyl sulfate (SDS) lie flat, arranged randomly on the basal plane of the MoS₂ nanosheets with their charged headgroup exposed. It was also shown that they exchange rapidly with free surfactants in the surrounding water. One of the most widely used classes of surfactants are facial amphiphiles such as sodium cholate (SC).^{105, 319, 324, 327-329, 331} As demonstrated in the original work,³¹⁹ such surfactant-based dispersions can be used to fabricate thin films or nanocomposites (*e.g.* by vacuum filtration) which can for example be used as electrodes in electrochemical water splitting.^{364, 365} However, as shown recently, SC can have detrimental effects for electrocatalysis³⁶⁶ which emphasizes that more research is required to explore strategies to remove physisorbed molecules/polymers after processing for certain applications.

In the case of non-ionic surfactants³³² or polymers,³³³⁻³⁴⁵ stabilization is due to steric effects that can be described in the framework of solution thermodynamics.³³⁴ In general, poloxamers (*e.g.* Pluronics)^{335, 339, 341, 344, 345, 367} are the most widely studied polymeric stabilizers. In particular Pluronic F68 has been used to decrease the buoyant density of the nanosheet-

polymer hybrid in water to allow for thickness sorting in a density gradient.³⁶⁷ Among the various structural characteristics, the thickness of the TMD sheets is known to define their properties; hence, the use of efficient layer number separation techniques is important. However, the yields of this process are currently low due to a low monolayer yield in the initial dispersion.³⁶⁷ This encouraged the authors to screen 19 different poloxamers with respect to their exfoliation efficiency (dispersed nanosheet concentration and monolayer content).³⁴¹ Nevertheless, as outlined in ref. 335, the presence of polymers during the exfoliation can result in poorer exfoliation compared to solvent or small molecule-assisted LPE in terms of mean layer number and lower dispersed concentration, as the surface tension of the liquid increases with the polymer concentration. The authors suggested to add the polymer stepwisely during the exfoliation to overcome this.³³⁵

In addition, a range of natural polymers/oligomers³⁴⁶⁻³⁶¹ have been exploited in the non-covalent functionalization as summarized in Table 2. These are typically used to obtain biocompatible TMDs for biomedical¹⁹⁸ and biosensing³⁶⁸ applications. Popular examples include chitosan,^{349, 350, 358, 359} bovine serum albumin^{351, 352} or oligonucleotide sequences.^{353, 354, 360} The interaction with the TMDs can be considered as predominantly van der Waals-type, while the stabilization is based on both Coulomb and steric repulsion.

Another non-covalent functionalization strategy is based on the electrostatic interaction of cationic molecules with negatively charged 1T-TMDs.³⁶⁹⁻³⁷¹ Such colloids are more stable than the 1T-MX₂ in water on its own³⁶⁹ or can be used for a solvent exchange to organic media.^{370, 371} Stabilization with oleylamine in high boiling point solvents such as octadecene or *o*-dichlorobenzene allows the conversion of 1T-MX₂ to 2H-MX₂ in the dispersions by heating without causing flocculation.³⁷¹

Even though the basal plane of TMDs is widely considered inert, a number of functionalization strategies *via* chemisorption have been developed. As illustrated in Fig. 14,

these can be classified as (i) covalent (ii) coordinative, (iii) defect or (iv) coordinative defect functionalization. Note that not all strategies are accessible from both 1T-CE-MX₂ and 2H-LPE-MX₂ or lead to a different result with respect to the degree of functionalization (number of functional groups per MX₂) or type of binding as illustrated in Fig. 15 and summarized in Table 2-6.

Covalent modification refers to a reductive functionalization of negatively charged 1T-CE-MX₂ with electrophiles and involves the formation of a carbon-chalcogen bond on the basal plane.^{78, 80, 196, 260, 372-374} In the first report by Voiry *et al.*,⁸⁰ CE-1T-MoS₂, -WS₂ and -MoSe₂ was reacted with alkyl halides (or an aryl diazonium salt). Similar to the first covalent functionalization of graphene,³⁷⁵ the electrophile attacks the negatively charged nanosheets. On charge neutralization, a covalent carbon-chalcogen bond is formed on the basal plane with degrees of functionalization of 20% (with respect to functional groups per MX₂ unit). The successful functionalization was evidenced by ¹³C-NMR spectroscopy, IR spectroscopy and X-ray photoemission spectroscopy (XPS). XPS spectra of functionalized 1T-MoS₂ (Fig. 16a) show evidence for a S-C in the S core level spectra in addition to the characteristic features of 1T, and 2H-MoS₂. The chalcogen-carbon bond is further observed in the IR spectra (Fig. 16b) in addition to the alkyl vibrations of the functional group. Importantly, the peak frequency shifts depending on the chalcogen as would be expected. The 1T-polytype is retained, but exhibits semiconducting properties after covalent functionalization due to the charge neutralization.

In a subsequent work, the question was addressed whether defects often present on CE-1T-MX₂ are required for successful functionalization.²⁶⁰ This was achieved by intercalating MoS₂ with excess MoS₂ over *n*-BuLi. Compared to the traditional intercalation that uses excess *n*-BuLi, a significant portion of the MX₂ (~50%) remains in its 2H-polytype as confirmed by XPS (Fig. 16c, d) and thermogravimetric analysis (TGA) revealed that the nanosheets are less

defective (Fig. 16e). Covalent functionalization of CE-2H/1T-MoS₂ with an aryldiazonium salt was evidenced (by XPS, IR spectroscopy and TGA coupled to mass spectrometry), albeit with lower degrees of functionalization (~10% per MoS₂ unit). In spite of this lower degree of functionalization, it is clear that defects or the 1T-polytype are not a prerequisite for the reductive functionalization and it will be possible to tailor the degree of surface decoration via the amount of charges initially present on the CE-MX₂. The 1T-polytype was found to convert rapidly (within a few days) into the 2H-polytype in the case of the CE-2H/1T-MoS₂ from intercalation using excess MoS₂. However, it is stabilized after functionalization. In analogy to the work by Voiry *et al.*,⁸⁰ it was suggested that it exhibits semiconducting properties. This covalent functionalization has subsequently been used to anchor various organic functionalities,^{78, 372-374} or to graft molecules on the TMD surface that can be used as ligands for further derivatization *via* coordination chemistry.^{373, 374} This approach is particularly interesting for catalytic applications. In a recent study, it has also been shown that 4-carboxy benzene diazonium salt can be reacted with edges of LPE-2H-MoS₂ in the presence of an amine catalyst.¹⁹⁶ Cross-linking of the edges in a network *via* hydrogen bonding provided the proof of concept that such edge functionalization sequences can play an important role in (opto)electronics in the future, as the authors observe a drastically increased charge-carrier mobility in the network. It is worth noting that despite MoS₂ nanosheets are known to behave as unipolar *n*-type semiconductors, the authors reported an unusual unipolar *p*-type transport, whose origin cannot be easily rationalized.

Alternatively, the basal plane of 2H-LPE-TMDs can be decorated by cationic metal complexes using the TMD chalcogens as ligands in a Lewis acid-base type of coordination chemistry.^{110, 376} This strategy builds on the work of Tremel *et al* on MoS₂-fullerenes³⁷⁷ and has recently been adapted for the functionalization of InSe.³⁷⁸ In particular Cu²⁺ ions were identified as suitable anchors to the TMD chalcogens (as evidenced by IR spectroscopy and

XPS). This strategy is interesting, as it is a rare example of the chemical basal plane functionalization of the semiconducting 2H-polytype which is retained after the functionalization.¹¹⁰ However, it remains little explored and further work will be required to demonstrate its versatility as well as possibilities of further derivatization.

The most commonly used chemisorption strategy exploits chalcogen vacancy defects to coordinate nucleophiles in dative bonds, in particular thiols^{112, 259, 379-388} with dithiolane³⁸⁹ used to a lesser extent. This functionalization concept often referred to as ligand conjugation was first introduced by Dravid and coworkers in 2013,²⁵⁹ where CE-1T-MoS₂ was reacted with a number of thiol-terminated polyethylene glycol derivatives bearing different ionic and non-ionic headgroups. This leads to a tuneable and pH-stable colloidal stability (Fig. 16g top). Zeta potential measurements suggest the successful decoration of the nanosheet surface, as the zeta potential could be tuned from ~-60-40 mV depending on the functional group. The disappearance of SH vibrations in the IR spectra indicate that thiols are deprotonated and the S bound to the MoS₂. In this strategy, CE-1T-MoS₂ is typically used,^{259, 380, 382-386, 388, 389} as it exhibits a higher density of sulfur vacancies than LPE-2H-MX₂ unless they are introduced on purpose.³⁸¹ However, as discussed in Sections 1.1 and 4.1, such defect sites (amongst others) are also observed in micromechanically-cleaved or CVD-grown monolayers,^{69, 157, 158, 164} so that this strategy is not restricted to liquid-suspended nanosheets.^{88, 293, 390} In the case of LPE-2H-MX₂, edge functionalization is believed to be more favourable, for example by coordinating polyacrylic acid¹⁹² or dithiolane derivatives^{194, 195} to metal-rich edges and thionine¹⁹³ or polybutadiene³⁹¹ to sulfur-rich edges, respectively. Note that in the latter two cases,^{193, 391} the ligand serves as an electron acceptor in the coordinative bond.

In some cases, thiol coordination to the basal plane of LPE-2H-MoS₂ has been suggested,^{379, 387} but no unambiguous proof (for example by the emergence of new species in the sulfur core level spectra in XPS) has been provided. Frequently, the disappearance of the S-H vibrations

in IR spectroscopy (for example Fig. 16g) serves as indicator for the successful defect functionalization. However, as demonstrated by McDonald and coworkers,²⁶¹ this can be due to a TMD-mediated dimerization of thiols to disulfides. In their work, the authors²⁶¹ added cysteine to LPE-2H-MoS₂ in isopropanol and observed a dimerization to cysteine and subsequent physisorption rather than a coordination of the thiol to the MoS₂. This was a puzzling observation, in particular because no thiol coordination could be evidenced in the reference experiment using CE-1T-MoS₂. DFT calculations by Li *et al.*¹⁸³ suggest that such a SV-mediated dimerization can be a thermodynamically favourable process. In their reaction pathway, a MoS₂ SV-mediated homolytic bond cleavage of the S-H is suggested as the first step which then leads to functionalized MoS₂ in an exothermic reaction prior to a potential dimerization. However, the activation energy for the dimerization was found to be high (91.5 kJ/mol) — unless free radicals are present — which does not properly account for the observation by McDonald and coworkers.

A recent theoretical work by Förster *et al.*¹⁸⁴ provides an alternative explanation to the question why sometimes defect functionalization occurs and sometimes dimerization of the thiol to disulfides. Their DFT calculations revealed that, depending on the nature of defects, an addition of a thiol results in either defect healing, coordination of the sulfur bearing ligand, or formation of disulfides/hydrodisulfides. For example, if sulfur vacancies are present, the thiol can coordinate to the exposed Mo *via* a transition state in an endothermic reaction, where the S-H bond is broken and the sulfur terminated molecule adsorbs to the exposed molybdenum and the hydrogen binds to a neighbouring sulfur atom on the MoS₂. This is followed by either vacancy healing or chemisorption of the functional group *via* the sulfur (accompanied with the release of hydrogen) in exothermic reactions. Based on the energetics, the vacancy healing should be favourable. However, if sulfur adatoms are present, the formation of a disulfide can occur in an exothermic reaction *via* a hydrodisulfide (net energy

release of ca. -1 eV) resulting in the formation of a disulfide and structurally perfect MoS₂ (adatom healing) accompanied by the release of H₂S, albeit with a high activation energy of ~3 eV. Energetics are more favourable if the hydrodisulfide interacts with a nearby sulfur vacancy. This theoretical work is an excellent foundation to explain the different experimental observations. For example, the work by Jeong *et al.*¹⁹⁴ showed *via* XPS that lipoic acid coordinates to LPE-2H-MoS₂ *via* the dithiolane group. This is in contrast to the above mentioned work by McDonald and coworkers, where no coordination (of neither disulfide nor thiol) was observed.²⁶¹ In both cases, LPE-2H-MoS₂ was used. However, the protocol differed in a significant aspect: in the case of the work by Jeong *et al.*,¹⁹⁴ the reagent lipoic acid was used directly as surfactant and was thus present during the LPE by sonication, while in the case of the study by McDonald and coworkers,²⁶¹ the reagent cysteine was added after the exfoliation in IPA was performed. Since theoretical work has shown that oxidation of MoS₂ can readily occur on both the sulfur vacant basal plane,³⁹² as well as edge,³⁹³ the coordination of the sulfur species can potentially be prevented in ambient conditions, if oxidation occurs prior to functionalization. Furthermore, it should be noted that chalcogen and vacancy defects are not the only defects that can be present. For example, numerous antisite defects have also been observed experimentally.¹⁶⁴ To fully exploit defect functionalization in TMDs, it will therefore be crucial to control both type and content of defects and systematically study their impact on the respective functionalization.

The chemistry of liquid-suspended TMDs can furthermore be exploited to decorate the nanosheets with noble metal (Au, Pt, Ag, Pd) nanoparticles (NPs). These structures are particularly interesting for catalysis, plasmonics or sensing.^{337, 394-408} The growth of can be achieved *via* non-covalently or covalently bound organic surface functionalities^{372, 383, 400, 401,}
⁴⁰³ nicely illustrating that TMD functionalization can be used to create hybrid structures. Alternatively, NPs can be grown directly on both CE-1T-MX₂ and LPE-2H-MX₂ nanosheets

after reduction of noble metal precursor salts.^{339, 394-399, 404, 409, 410} Typically, an additional reducing agent is added,^{394, 396-399, 409} even though the spontaneous formation (*i.e.* without additional reducing agent) has also been observed in some cases.^{339, 394, 395, 404, 410} This is documented to be the case when CE-1T-MoS₂^{394, 395, 410} or CE-1T-WS₂³⁹⁵ are used. In such a way, a number of noble metal nanoparticles like Pd, Pt or Au can be epitaxially grown on the 1T-MX₂ surface. Typical TEM images are shown in Fig. 17a-c. Notably, decoration occurs on the basal plane and XPS (for Au-decorated nanosheets in Fig. 17d) does not show evidence for a covalent binding. This is likely because the excess charges of the CE-MX₂ can reduce the metal precursor salt resulting in the nucleation of physisorbed nanoparticles on both basal plane and edge. (Note that the non-covalent binding has not been unambiguously confirmed in all reports).

In contrast to these reports on CE-1T-MoX₂, a covalent bond formation between the sulfur of the TMD and AuNPs was demonstrated according to XPS (Fig. 17e) in hybrid materials obtained after reaction of HAuCl₄ with LPE-2H-WS₂ in the absence of additional reducing agents.⁴⁰⁴ In this case, the NPs are predominantly located at nanosheet edges and terraces of incompletely exfoliated nanosheets (Fig. 17f). It was suggested that thiol functionalities present on edges and defect sites act as reducing agent for the initial nucleation resulting in a conversion to disulfides, as indirectly confirmed by an increased electrocatalytic activity in the hydrogen evolution reaction, where disulfides are the predominant active sites.⁴¹¹ Due to the higher mass of Au-decorated WS₂ opposed to the native WS₂ in combination with the edge decoration, an enrichment of monolayers was readily achieved by centrifugation resulting in WS₂ dispersions with monolayer volume fractions of 50-90% (depending on the initial lateral size of the LPE-WS₂) with a sparse decoration of nanoparticles around the edges (Fig. 17g). The optical properties of the semiconducting 2H-polytype (*e.g.* photoluminescence

of monolayers) were retained making these hybrids potentially interesting for printed optoelectronics.

By and large, the (multi)functional inks developed by combining TMDs with suitably designed molecules can express unique functionalities which are resulting from those determined by the individual components. Their processing and integration for device applications (*e.g.* in opto-electronics, photonics, sensing, *etc.*) can be carried out using up-scalable methods such as printing (ink-jet, roll-to-roll, *etc.*) and spray-coating, and the devices can be easily supported on flexible foils, opening new intriguing perspectives in the fields of flexible, foldable and wearable (opto)electronics.

Table 2. Functionalization of solution-processed group-6 TMD nanosheets *via* physisorption of molecules, polymers and biopolymers.

Ref.	Interaction	Molecule or (bio)polymers	2D material	Exfoliation Method	Medium	Reason for functionalization
<i>Molecules</i>						
319	van der Waals	sodium cholate (SC)	2H-MoS ₂	sonication	aqueous	stabilization in LPE
322	van der Waals	<i>p</i> -phosphonic acid calix[8]arene	2H-MoS ₂ , 2H-WS ₂	sonication	aqueous	stabilization in LPE
323	van der Waals	sodium dodecyl sulfate (SDS)	2H-MoS ₂	ball milling	aqueous	stabilization in LPE, gas sensing
369	electrostatic	hexadecyltrimethylammonium chloride (CTAC)	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	stabilization after chemical exfoliation
325	van der Waals	alkyl-trichlorosilanes	2H-MoS ₂	sonication	1,2 dichloro-benzene	stabilization after LPE, thin film formation
370	electrostatic	cetyltrimethylammonium bromide (CTAB), chitosan (CS)	1T-MoS ₂	CE <i>n</i> -BuLi (hydrothermal)	aqueous, then redispersion in dimethylformamide	transfer to organic solvent; polymer composites
324	van der Waals	sodium cholate (SC)	2H-MoS ₂ , 2H-WS ₂	sonication	aqueous	stabilization in LPE for size selection
371	electrostatic	oleylamine	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous, then transfer to various organic	phase transfer to organic solvents; conversion to 2H-MoS ₂ in high boiling point solvent
326	van der Waals	sodium dodecyl sulfate (SDS), cetyltrimethylammonium bromide (CTAB)	2H-MoS ₂	sonication	aqueous	stabilization in LPE
105	van der Waals	sodium cholate (SC)	2H-MoS ₂	shear exfoliation	aqueous	stabilization in LPE
327	van der Waals	sodium deoxycholate (SDC)	2H-MoS ₂	sonication	aqueous	stabilization in LPE, mixing with PVA for composite fabrication
328	van der Waals	sodium cholate (SC)	2H-WS ₂	sonication	aqueous	stabilization in LPE for size selection
329	van der Waals	sodium cholate (SC)	2H-MoS ₂ , 2H-WS ₂	dry ball milling	aqueous	stabilization
330	van der Waals	2,3,6,7,10,11-hexahydroxytriphenylene and derivatives	2H-MoS ₂	sonication and dry ball milling	various	stabilization in LPE

331	van der Waals	sodium cholate (SC)	MoTe ₂ , WTe ₂	sonication	aqueous	stabilization in LPE, mixing with PVA for composite fabrication
<i>Polymers or biopolymers</i>						
332	van der Waals	polyoxyethylene sorbitan monooleate (Tween 80), polyoxyethylene sorbitan trioleate (Tween 85), polyvinylpyrrolidone (PVP), polyoxyethylene dodecyl ether (Brij 30), polyoxyethylene octadecyl ether (Brij 700), polyoxyethylene octyl phenyl ether (Triton X-100), gum arabic, Pluronic P-123, n-Dodecyl β-D-maltoside (DBDM)	2H-MoS ₂ , 2H-WS ₂	sonication	aqueous	stabilization in LPE
334	van der Waals	polybutadiene (PBD), poly(styrene-co-butadiene) (PBS), polystyrene (PS), poly(vinyl chloride) (PVC), poly(vinyl acetate) (PVAc), polycarbonate (PC), poly(methyl methacrylate) (PMMA), poly(vinylidene chloride) (PVDC), cellulose acetate (CA).	2H-MoS ₂	sonication	tetrahydrofuran	stabilization in LPE
346	van der Waals	gelatine	2H-MoS ₂ , 2H-WS ₂	sonication	aqueous	stabilization in LPE, gelatine composites
345	van der Waals	Pluronic F108	2H-WS ₂	sonication	aqueous	stabilization in LPE
335	van der Waals	Pluronic P123, Pluronic F127	2H-MoS ₂	sonication	aqueous	stabilization in LPE, photocatalysis
347	van der Waals	pyrene-derivatized hyaluronic acid	2H-MoS ₂	sonication	aqueous	stabilization in LPE
336	electrostatic	assembly on poly(allylamine hydrochloride) (PAH), and poly(styrenesulfonate) (PSS)	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	electrostatic layer by layer assembly
367	van der Waals	Pluronic F68	2H-MoS ₂ , 2H-WS ₂	sonication	aqueous	thickness sorting in density gradient after LPE
337	van der Waals	polyvinylpyrrolidone (PVP)	2H-MoS ₂	sonication and supercritical CO ₂	ethanol/H ₂ O	stabilization in LPE, cell labelling
348	van der Waals	chitosan	2H-MoS ₂	sonication	aqueous	stabilization in LPE, chitosan composites
349	van der Waals	hemin	2H-MoS ₂ , partial conversion to 1T	sonication	methanol, then redispersion in H ₂ O	Stabilization in LPE, fabrication of H ₂ O ₂ sensor

350	van der Waals	chitosan	2H-MoS ₂	sonication after oleum pre-treatment	aqueous	stabilization, chemotherapeutic drug nanocarrier
351	van der Waals	bovine serum albumin, then methylene blue	Acid-exfoliated WS ₂	H ₂ SO ₄ intercalation	aqueous	stabilization, photosensitization
338	van der Waals	polyvinylpyrrolidone (PVP)	2H-MoS ₂	sonication	various	stabilization in LPE, film formation
339	van der Waals	Pluronic P123	2H-MoS ₂	sonication	aqueous	stabilization in LPE, anchor for AuNPs to enhance photocurrent
340	van der Waals	poly(ureamethylvinyl)silazane	Acid exfoliated MoS ₂	chlorosulfonic acid exfoliation	aqueous	formation of amorphous SiCN ceramic for Li ion batteries
401	van der Waals	polydopamine	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	stabilization after chemical exfoliation, nanoparticle decoration
352	van der Waals	bovine serum albumin	2H-MoS ₂	sonication	aqueous	stabilization in LPE, biocompatible nanosheets
353	van der Waals	DNA oligonucleotides	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	surface functionalization for a prostate specific antigen sensor
354	van der Waals	DNA oligonucleotides	2H-MoS ₂	sonication (initially in SC)	aqueous	stabilization at high ionic strength
355	van der Waals	nanofibrillated cellulose	2H-MoS ₂	sonication	aqueous	stabilization in LPE, composite formation
356	van der Waals	alkali lignin	2H-MoS ₂ , 2H-WS ₂	sonication	aqueous	stabilization in LPE
357	van der Waals	guar gum, xanthan gum, tannic acid	2H-MoS ₂	sonication	aqueous	stabilization in LPE
358	van der Waals	chitosan	2H-MoS ₂	sonication	aqueous, then tetrahydrofuran	stabilization in LPE, composite formation (epoxy resin) in tetrahydrofuran
359	van der Waals	chitosan	2H-MoS ₂	ionic liquid (IL) assisted grinding	IL, then aqueous	biocompatible nanosheets in water
341	van der Waals	19 different poloxamers (<i>i.e.</i> , Pluronics and Tetronics)	2H-MoS ₂	sonication	aqueous	stabilization in LPE, biocompatible dispersions
343	van der Waals	polyvinylalcohol (PVA)	2H-WS ₂	sonication	aqueous	stabilization in LPE, composite fabrication
344	van der Waals	Pluronic F108	2H-WS ₂	sonication	aqueous	stabilization in LPE, isolation of nanodots for HER
342	van der Waals	tetrathiafulvalene (TTF)-substituted polymers	1T-MoS ₂	CE <i>n</i> -BuLi	redispersion in tetrahydrofuran	stabilization after chemical exfoliation, chemical doping

360	van der Waals	DNA oligonucleotides	2H-WS ₂ , 2H-WSe ₂	sonication	aqueous	stabilization in LPE, biocompatible nanosheets
412	van der Waals	bovine serum albumin, then resveratrol	2H-MoS ₂	sonication	aqueous	stabilization in LPE, biocompatible nanosheets
361	van der Waals	cross-beta-amyloid (protein nanotubes)	2H-MoS ₂	sonication	aqueous	stabilization in LPE, stimuli responsive dispersions

Table 3. Functionalization of solution-processed TMD nanosheets *via* coordination chemistry on defects (dative bonds of nucleophiles) and on basal plane (Lewis acid-base chemistry).

Ref.	Suggested binding	Functional group	2D material	Exfoliation Method	Medium	Reason for functionalization
Coordination chemistry on defects (dative bonds of nucleophiles)						
259	thiol coordination to S vacancies	thiol-terminated polyethylene glycol with various headgroups	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	proof of concept
379	thiol coordination to S vacancies + van der Waals	thioglycolic acid	2H-MoS ₂	sonication	aqueous	stabilization in LPE
389	dithiolane coordination to S vacancies	lipoic acid conjugated polyethylene glycol	1T-WS ₂ , 1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	biocompatible nanosheets as theranostic agent or in drug delivery
380	thiol coordination to S vacancies	dithioglycol	1T-MoS ₂	CE <i>n</i> -BuLi (hydrothermal)	tetrahydrofuran	nanocomposites with octa-vinyl polyhedral oligomeric silsesquioxanes (improved thermal, mechanical, flame-retardant properties)
381	thiol coordination to S vacancies	mercaptoundecanoic acid	2H-MoS ₂	sonication (to introduce defects)	ethanol/H ₂ O	sensor for volatile organic compounds
382	thiol coordination to S vacancies	dodecanethiol	1T-MoS ₂	CE <i>n</i> -BuLi	acetone	proof of concept: transfer to organic solvents
192	coordination of COOH to S vacancies (predominantly. at edges)	polyacrylic acid	2H-WS ₂	sonication	aqueous	stabilization in LPE and fabrication of a biosensor with adsorbed ss-DNA
383	thiol coordination to S vacancies	mercaptopropionic acid, 1-Thioglycerol, L-Cysteine	1T-MoS ₂	CE <i>n</i> -BuLi (hydrothermal)	aqueous	proof of concept; further derivatization by in situ reduction of metal ions, esterification, polymerizations
384	thiol coordination to S vacancies	meso-2,3-dimercaptosuccinic acid-modified iron oxide nanoparticles, then lipoic acid terminated polyethylene glycol and amine-terminated branched PEG	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	TMD-based nanoplatform for multimodal imaging-guided photothermal therapy of cancer
112	thiol coordination to S vacancies	p-mercaptophenol, thiophenol, 1-propanethiol, 1-nonanethiol, and 1-dodecanethiol	2H-MoS ₂	two solvent grinding assisted sonication	ethanol	proof of concept (comparison of various thiols)

261	no thiol coordination, but physisorbed dimer	physisorbed cystine produced from cysteine	2H-MoS ₂	sonication	isopropanol	proof of concept
194	dithiolane coordination to S vacancies mainly at edges	lipoic acid	2H-MoS ₂	sonication	aqueous	proof of concept
385	thiol coordination to S vacancies	thiol-terminated tetra ethylene glycol with various head groups	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	2D material antibiotic
386	thiol coordination to S vacancies	thioglycolic acid	1T-MoS ₂	CE <i>n</i> -BuLi (hydrothermal)	H ₂ O, H ₂ O/tetrahydrofuran for composite	polymer composite (chitosan, improved mechanical and thermal properties)
387	thiol coordination to S vacancies	N,N'-bis(p-thiophenylamido) diethylenetriamine-N,N',N''-triacetic and complexation with Eu ³⁺ and Gd ³⁺	2H-MoS ₂	sonication	isopropanol	proof of concept, introduction of magnetic and tailored light emission
388	thiol coordination to S/Se vacancies	thiobarbituric acid	1T-MoS ₂ , 1T-WS ₂ , 1T-MoSe ₂ , 1T-WSe ₂	CE <i>n</i> -BuLi	aqueous	proof of concept, preservation of metallic 1T phase
195	sulfur addition at molybdenum edges	1,2-dithiolane derivatives bearing ethylene glycol alkyl chain terminated to a butoxycarbonyl (BOC)-protected amine or a pyrene	2H-MoS ₂	acid-assisted liquid exfoliation (sonication)	chlorosulfonic acid, then dimethylformamide	proof of concept, fabrication of donor-acceptor hybrids

Coordination chemistry on basal plane (Lewis acid-base chemistry)

376	Metal (Cu ²⁺) ion coordination	cross-linking at edge sites <i>via</i> polymer	2H-MoS ₂	sonication	dimethylformamide	mechanical robustness, polymer composite, reduced graphene oxide (rGO) composite as electrode in Li ion batteries
110	Metal ion (Cu ²⁺ , Ni ²⁺ , Zn ²⁺) coordination	acetates (<i>via</i> metal cations)	2H-MoS ₂	sonication	isopropanol	proof of concept

Table 4. Reductive covalent basal plane functionalization of solution-processed TMDs with electrophiles. Notes: (*) Different intercalation conditions.

Ref.	Reagent	Functional group	2D-material	Exfoliation Method	Medium	Reason for functionalization
80	<i>via</i> alkyl halides, aryl diazonium salts	alkyl, 4-methoxybenzene	1T-MoS ₂ , 1T-WS ₂ , 1T-MoSe ₂	CE <i>n</i> -BuLi	aqueous	proof of concept
260	<i>via</i> aryldiazonium salts	4-methoxybenzene	1T/2H-MoS ₂	CE <i>n</i> -BuLi (*)	aqueous	proof of concept
196	<i>via</i> 4-carboxy-benzenediazonium salt	4-carboxybenzene	1T-MoS ₂	CE <i>n</i> -BuLi	dimethylformamide (DMF)	reference system to edge functionalized 2H-MoS ₂ in thin film transistor
78	<i>via</i> organohalides	benzene, 4-methoxybenzene, 4-nitrobenzene, porphyrin, pyrene derivatives	1T-MoS ₂ , 1T-MoSe ₂ , 2H-MoS ₂ and 2H MoSe ₂ (with Pd0 catalyst)	CE <i>n</i> -BuLi, sonication	H ₂ O/DMF (1T), DMF (2H)	proof of concept
373	<i>via</i> 4-Cyanobenzyl diazonium salt	4-cyanobenzol and coordination to cobaloxime	1T-MoS ₂	CE <i>n</i> -BuLi	aqueous	improved HER electrocatalyst
374	<i>via</i> 5-Bromomethyl-2,2'-bipyridine	methyl-2,2'-bipyridine and coordination to RuII(bpy)2Cl ₂	1T-MoS ₂	CE <i>n</i> -BuLi	H ₂ O/ethanol	improved HER electrocatalyst

Table 5. Decoration of solution-processed TMDs with noble metal nanoparticles.

Ref.	Method/suggested binding	Nanoparticle and 2D material	Exfoliation Method	Precursor Salt	Reducing Agent	Reason for functionalization
394	epitaxial growth on basal plane	Pd, Pt, Au on MoS ₂	electrochemical Li intercalation	K ₂ PdCl ₄ , K ₂ PtCl ₄ , HAuCl ₄	Pd: CTAB/ascorbic acid; Pt: trisodium citrate; Au: Trisodium citrate	proof of concept, hybrids for electrocatalysis
395	spontaneous formation at defect sites and edges (physisorption)	Au on 1T-MoS ₂ , 1T-WSe ₂	CE <i>n</i> -BuLi	HAuCl ₄	none	proof of concept, hybrids for electrocatalysis
409	metal nuclei seeding on defect sites (basal plane)	Au, Ag on 2H-MoS ₂	sonication in NMP	HAuCl ₄ , AgNO ₃	hydroxyl amine, microwave	proof of concept, improve transport behavior
396	self-assembly on basal plane	Au on 2H-MoS ₂	L-cysteine assisted exfoliation	HAuCl ₄	NaBH ₄	fabrication of an aptasensor <i>via</i> layer by layer deposition
397	self-assembly on basal plane	Ag on 2H-MoS ₂	sonication in NMP (+ chitosan stabilizer)	AgNO ₃	ascorbic acid	electrocatalysis (tyrophan oxidation)
398	epitaxial growth on basal plane	Au on MoS ₂	electrochemical Li intercalation	HAuCl ₄	ascorbic acid	Au NP plasmon enhanced photocatalytic water-splitting
399	self-assembly on basal plane (physisorption)	Au, Ag, Pt, Pd on 1T-MoS ₂	CE <i>n</i> -BuLi (+carboxymethyl cellulose stabilizer)	HAuCl ₄ , AgNO ₃ , H ₂ PtCl ₆ , PdCl ₂	microwave	proof of concept, Pd-MoS ₂ for electrocatalysis (methanol oxidation)
383	growth on COOH on basal plane functionalized MoS ₂	Ag on functionalized MoS ₂	thiol coordination after CE	AgNO ₃	NaBH ₄	proof of concept
400	growth on COOH on basal plane functionalized MoS ₂	Pt, Au, Fe ₃ O ₄ , CdS ₂ , PbS on functionalized MoS ₂	thiol coordination after CE	K ₂ PtCl ₄ , HClAu ₄ , FeCl ₃ , CdCl ₂ , Pb(CH ₃ COO) ₂	Pt, Au: NaBH ₄ ; Fe ₃ O ₄ : NaOH; CdS ₂ and PbS: Na ₂ S	proof of concept, production of ternary systems for photocatalysis (reduction of 4-nitrophenol)
339	growth on MoS ₂ edges and basal plane	Au on 2H-MoS ₂	sonication in aqueous Pluronic P123	HAuCl ₄	none	cathode buffer layers in organic photovoltaic devices
401	growth on poly dopamine layer surrounding MoS ₂	Pt, Au on 1T-MoS ₂ with self-polymerised dopamine	CE, reaction with dopamine hydrochloride	H ₂ PtCl ₆ , HAuCl ₄	none	proof of concept, photocatalysis

372	growth on COOH on basal plane functionalized MoS ₂	Ag on functionalized 1T-MoS ₂	CE and reductive functionalization	AgNO ₃	NaBH ₄	proof of concept
402	growth on PVP on basal plane of MoS ₂ (physisorption)	Au, Au/Pt on 1T-MoS ₂ with PVP coating	CE <i>n</i> -BuLi	HAuCl ₄ , then H ₂ PtCl ₆	none for Au, then CTAB/acetic acid for Pt	electrocatalysis (oxidation of methanol)
410	spontaneous formation binding to defect sites and edges (physisorption)	Au on 1T-MoS ₂	CE <i>n</i> -BuLi	HAuCl ₄	none	further derivatization <i>via</i> thiol click chemistry
403	growth on PVP on basal plane and edge (physisorption)	Pd on 2H-WS ₂	LPE in NMP, (+ PVP, ethylene glycol)	Pd(OAc) ₂	ethylene glycol	photocatalysis (Suzuki reactions)
404	chemisorption through reaction with thiol edge sites (and basal plane defects to minor extent)	Au on 2H-WS ₂	LPE in aqueous SC	HAuCl ₄	none	proof of concept (different mechanism resulting in chemisorption), monolayer enrichment, electrocatalytic hydrogen evolution

Table 6. Additional methods for the functionalization of solution-processed TMD nanosheets.

Ref.	Type of reaction	Functional group	Layered material	Exfoliation Method	Medium	Reason for functionalization
413	oxidation	oxides and chlorosulfonic acid	2H-WS ₂	acid intercalation and oxidation	chlorosulfonic acid, then water	proof of concept, electrode in Li ion battery
193	coordination to negatively charged S-edge	thionine	2H-MoS ₂	ionic liquid assisted sonication	ionic liquid (IL), then DMF	fabrication of a double-stranded DNA electrochemical biosensor
391	binding of edge S to polybutadiene	polybutadiene	2H-MoS ₂	sonication	N-methyl-2-pyrrolidone	proof of concept, polymer composite
196	reaction of 4-carboxy-benzenediazonium salt with S-rich edges in the presence of amine	4-carboxybenzene	2H-MoS ₂	“solvation” in dimethylformamide (DMF)	DMF	cross-linking of edges of functionalized 2H-MoS ₂ <i>via</i> hydrogen bonding in thin film transistor

6. Recent progress in the chemistry of TMDs “beyond MoWSeS”

Besides MoWSeS materials, other TMDs (group-6 tellurides, groups 4, 5, 7 and 10) possessing diverse chemical and physical properties are attracting nowadays a great deal of attention. In general, the electronic structures of TMDs are strongly dependent on the d -electron number of the transition metal.¹¹⁵ TMDs with many (group 7, 10) or few (group 4) d -electrons are prone to form d^2sp^3 hybridization, which results in the 1T-phase (or distorted 1T') structure.^{115, 414} In terms of electronic transport, they mostly exhibit semiconducting properties. In contrast, TMDs of the group 5 and 6 are prone to form d^4sp hybridization with 1H structure and behave as narrow-band metals or semimetals with superconducting properties.^{115, 410} By taking advantage of chemical functionalization strategies, diverse and novel properties of TMDs may emerge and be used for device applications.

The interaction between ferromagnetism (FM) and superconductivity (SC) is a cutting-edge research topic.⁴¹⁵ It is well known that FM can destroy singlet correlations responsible for SC, and therefore it is quite rare to find materials that simultaneously exhibit both properties.⁴¹⁶ Recently, the coexistence of FM and SC was observed in chemically-exfoliated 2H-NbSe₂ (group 5) nanosheets upon chemical treatment with hydrazine molecules.¹¹⁴ Pristine NbSe₂ is a superconducting yet non-magnetic material since the magnetic moment of Nb⁴⁺ ($4d^1$ configuration) is quenched due to the Nb-Se hybridization. Zhu *et al.*¹¹⁴ found that the adsorption of reducing hydrazine molecules on the surface of NbSe₂ (Fig. 18a) induces a structural distortion, *i.e.* elongated Nb-Se bonds and weaker Nb-Se interactions. Such a distortion leads to the emergence of a net magnetic moment with ordered spin behaviour resulting in ferromagnetic properties. Fig. 18b displays the magnetic hysteresis loop at 30 K, which provides evidence for the existence of FM in NbSe₂.¹¹⁴ Moreover, the abrupt drop in electrical resistivity R occurring at temperature $T \leq 6$ K (see Fig. 18c) confirms that the hydrazine treatment does not suppress the SC properties. Hence, the adsorption of hydrazine

molecules is an effective method to modulate the electrical — see also discussion in Section 2.1 — and magnetic properties of TMDs *via* chemical approaches.

Monolayer MoTe₂ (group 6) has emerged as a promising phase-change material due to the small energy difference (~ 31 meV)⁴¹⁷ between the semiconducting 1H and metallic 1T' polytypes,^{146, 147} which makes it possible to trigger phase transitions *via* electrostatic doping.¹⁴⁷ Theoretical calculations by Zhou *et al.*⁴¹⁷ predict that molecules (*e.g.* H₂, H₂O, NH₃, CO and N₂) and atoms (*e.g.* Li, Na, K, O and Cl) adsorbed on the surface of the 2D sheet can stabilize the 1H and 1T' phase, respectively. In this framework, new experimental studies are foreseen to explore the use of molecular approaches — for instance based on the “decoration” of the top and bottom surface (see Section 2.2) — to control the phase state and therefore also the electrical properties of ultrathin MoTe₂.

Group-10 TMDs are gathering attention due to their thickness-dependent bandgap and high charge-carrier mobility.^{144, 414} For instance, bulk PdSe₂ and PtSe₂ are semimetals whereas thin sheets of these materials (thickness ≤ 10 nm) display small semiconducting bandgaps.^{144, 411} FETs based on ~ 9 nm thick sheets of PdSe₂ (group-10) show ambipolar transport characteristics with electron/hole field-effect mobility (μ_{FE}) up to $\sim 54/14$ cm²V⁻¹s⁻¹ and $I_{\text{on}}/I_{\text{off}}$ ratio of ~ 100 .¹¹³ After a thermal annealing step under vacuum, which is commonly performed to remove environmental adsorbates (*i.e.* H₂O and O₂), the devices show unipolar *n*-type transport with $\mu_{\text{FE}} \approx 216$ cm²V⁻¹s⁻¹ and $I_{\text{on}}/I_{\text{off}} \approx 10^3$ (Fig. 18d). However, ambipolar as well as unipolar *p*-type transport has also been achieved *via* physisorption of acceptor molecules, namely F₄-TCNQ (see Section 2.1). Electrical transport measurements in Fig. 18e demonstrate that the charge-carrier density in F₄-TCNQ-treated PdSe₂ FETs can be effectively modulated by controlling the amount of physisorbed molecules. By increasing the number of molecular dopants, the authors succeeded in achieving a unipolar *p*-type transport (red curve in Fig. 18e). Overall, they showed that the combination of thermal annealing and molecular

physisorption doping is a promising route to control the charge-carrier polarity in narrow-bandgap semiconductors towards complementary logic devices and circuits.

Wan *et al.*⁴¹⁸ prepared and characterized a promising *n*-type flexible thermoelectric material based on hybrid superlattices of semiconducting 1T-TiS₂ (group 4) and organic cations. TiS₂ single crystals were electrochemically intercalated with hexylammonium (HA) ions dissolved in dimethyl sulfoxide (DMSO). After solvent exchange from DMSO to water the resulting compound — *i.e.* TiS₂[(HA)_{0.08}(H₂O)_{0.22}(DMSO)_{0.03}] — showed a remarkably low in-plane thermal conductivity ($\sim 0.12 \text{ W m}^{-1} \text{ K}^{-1}$), significantly lower than that of pristine TiS₂ crystals ($4.2 \text{ W m}^{-1} \text{ K}^{-1}$) where the layers interact *via* weak van der Waals forces. On the other hand, negatively-charged TiS₂ layers and organic cations in the hybrid system are coupled *via* strong electrostatic interactions,⁴¹⁸ which degrade the in-plane thermal conductivity due to phonon scattering. The combination of high electrical conductivity — typical of TiS₂ — with the low thermal conductivity of the intercalated compound, allowed achieving a figure of merit ZT as high as ~ 0.28 ($T \approx 373 \text{ K}$), which is close to that of the most promising *p*-type organic thermoelectric materials, *i.e.* poly(3,4-ethylenedioxythiophene) polystyrene sulfonate (PEDOT:PSS).

Finally, ultrathin ReSe₂ (group 7) is an appealing material for optoelectronic applications due to its wide photoresponse range. The performance of photodetectors based on ReSe₂ nanosheets has been significantly improved by *n*-type doping *via* physisorption of triphenylphosphine (PPh₃) molecules.¹⁰¹ In comparison to their untreated counterparts, PPh₃-treated ReSe₂ FETs were found to display lower contact resistance, higher charge-carrier mobility, as well as enhanced photocurrent — by approximately a factor of 4 — under monochromatic light irradiation ($\lambda \approx 520 \text{ nm}$).

By taking advantage of the exotic properties of TMDs beyond group 6 and of their tunability *via* molecular chemistry methods, advanced optoelectronic, magnetic, as well as

thermoelectric materials can be developed, paving the way towards novel applications based on molecule-TMD hybrids.

7. Conclusions and outlook

The large variety of materials/properties available in the TMD family combined with the virtually-infinite number of functional molecular systems available through chemical synthesis provide countless opportunities to engineer hybrid organic/inorganic nanomaterials with on-demand characteristics for device applications. In such hybrids, new functionalities can be introduced in a chemically controlled manner by tailoring the interactions between molecules ultrathin crystalline materials,¹⁹⁹ thereby opening further possibilities for developing multifunctional/multiresponsive materials and devices. Hereafter, we will discuss these newly emerging research fronts, as well as the prospects and the challenges towards next-generation technologies based on molecule-TMD hybrid materials.

Hybrid van der Waals heterostructures. The molecular chemistry approaches to TMDs present several analogies to the quest for materials by design carried out by superimposing different inorganic 2D materials in the so-called van der Waals heterostructures (Fig. 19a).^{419,}
⁴²⁰ Molecules can be incorporated into these layered structures to generate novel hybrid materials in which unique molecular capabilities are combined with the ultra-high electrical performances of TMDs and other 2D materials. Towards this goal, molecular science offers a variety of opportunities which have not yet been fully exploited.

So far, relatively few studies exploit the possibility to generate highly predictable self-assembled molecular monolayers on the surface of TMDs^{219, 252, 253, 421, 422} and impart them on-demand functions. Indeed, the molecular arrangement on TMD surfaces is determined by supramolecular interactions which can be predicted and controlled by molecular design. Mastering molecular self-assembly offers the possibility to incorporate specific functional

groups (such as dopants) at pre-determined spatial locations, paving the way to a direct correlation between electrical effects measured at the device level and events taking place at the molecular scale. Moreover, such molecular chemistry approaches ensure an atomic precision that outperforms conventional lithographic techniques,⁴²³⁻⁴²⁵ and molecular monolayers self-align with respect to the crystalline direction of the underlying substrate giving rise to epitaxial growth.^{426, 427} On graphene, this approach was exploited to induce controllable periodic potentials⁹³ and demonstrate tunable doping.⁴²⁸

The same ultra-high control over the nanoscale molecular ordering can be achieved in the case of TMDs.⁸¹ Recently, Wang *et al.*²⁵² demonstrated that oleamide generates analogous crystalline structures on the surface of different 2D materials, including several TMDs - MoS₂, MoSe₂, MoTe₂, WSe₂ (Fig. 19 b-d). Within the SAMs, oleamide molecules lie flat on the substrate surface, and intermolecular hydrogen bonds drive the formation of parallel rows, which are aligned to the crystallographic orientation of the 2D materials (Fig.16e). In this regard, the growth is epitaxial and atomically precise, with single crystalline molecular domains extending over regions above 0.5 $\mu\text{m} \times 0.5 \mu\text{m}$ (Fig.16 b-d).²⁵² Whether the structural 1D anisotropy of the assembly induces anisotropy in the electronic properties of the underlying TMD remains an open question, which can only be answered by an investigation of electrical transport and optical characteristics of regions covered by a single crystalline molecular domain. In turn, this goal poses the challenge of maximizing the size of molecular crystalline domains, and of fabricating nanoscale device which preserve the molecular monolayers. Finally, we highlight that molecular decoration affects not only the optoelectronic, but also the magnetic properties of TMDs,^{114, 429} opening interesting avenues for spintronics based on TMD/molecules heterostructures. In perspective, the ability to generate heterostructures with engineered properties can be exploited to build up a library of novel hybrid materials with on-demand properties.

Multifunctional materials and devices. Combining molecular systems with ultrathin TMDs allows not only to control the charge-carrier doping of 2D semiconductors but also to modulate their optical, thermal and sensing properties in hybrid systems. Such an approach makes it also possible to impart a multifunctional/multiresponsive nature to 2D TMDs that can be conveniently exploited for developing multifunctional (opto)electronic devices, which can be controlled with multiple independent stimuli. For instance, by making use of the different molecular chemistry methods discussed in this review, 2D sheets of TMDs could be functionalized with molecules carrying photochromic,⁴³⁰⁻⁴³² magneto-responsive⁴³³ and electrochemically-switchable^{434, 435} moieties. External stimuli, such as heat, light, magnetic fields and electrochemical signals, can then be used to trigger changes in the structures/properties of the molecules interfacing the ultrathin sheets. Thanks to their ultimately-large surface to volume ratio, ultrathin TMDs are expected to respond to such changes with variations in their electrical, optical and magnetic characteristics. One interesting example has been recently provided by Datta *et al.*,⁴²⁹ who developed FETs based on monolayer MoS₂ sheets “decorated” on the top surface with magnetic molecules, such as quinoidal dithienyl perylenequinodimethane (QDTP). The latter undergo a spin transition from a singlet to a triplet state with increasing temperature above ~370 K. This spin-state switch could be electrically transduced by the MoS₂ sheet, which displayed an increase in the free electron density (n doping) and a strong enhancement in magnetoconductance (~100%) above the magnetic transition temperature. This work demonstrated that the electrical/magnetic properties of monolayer MoS₂ could be dynamically modified through the interaction with switchable molecular systems. In the next years, further research is envisioned towards multifunctional/multiresponsive materials and devices based on combinations of ultrathin TMDs and molecular switches.

Next challenges. In order to take full advantage of TMD-molecule hybrids in technological applications, various challenges have to be addressed. Besides the aforementioned requirement to control/enlarge the size of physisorbed molecular crystal domains, an important task towards hybrid TMD-molecule (opto)electronics consists in developing suitable techniques (*e.g.* encapsulation) to prevent desorption or decomposition of molecules during device operation. It is also of paramount importance to achieve a systematic control over the degree of functionalization in both solution-processed and substrate-supported 2D sheets. The latter should be carefully quantified through multiple experimental techniques and must be systematically controlled, especially in the case of optoelectronic devices and sensing technologies, where uniform and reproducible optical, electronic and sensing properties must be achieved across the entire active material's surface. However, such requirement might not be so stringent for multifunctional foams and composites,⁴³⁶ or for biomedical applications,¹⁹⁸ which could be the first areas where hybrid molecule-TMDs could find practical application, in order to address societal needs in energy generation and storage as well as water purification and highly selective gas and ion sensors. Towards the improvement of the quality of our lives, in the forthcoming years the development of structurally defined, novel hybrid materials based on TMDs and suitably designed molecules, shall open a new technological era relying on portable, flexible and foldable multiresponsive (opto)electronic devices for health and environmental monitoring. The full exploitation of the infinite options offered by molecular science in terms of structural and functional diversities shall soon yield to the emergence of new, disruptive and exotic technologies based on TMDs hybrids.

Conflict of interest

There are no conflicts to declare.

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Figures

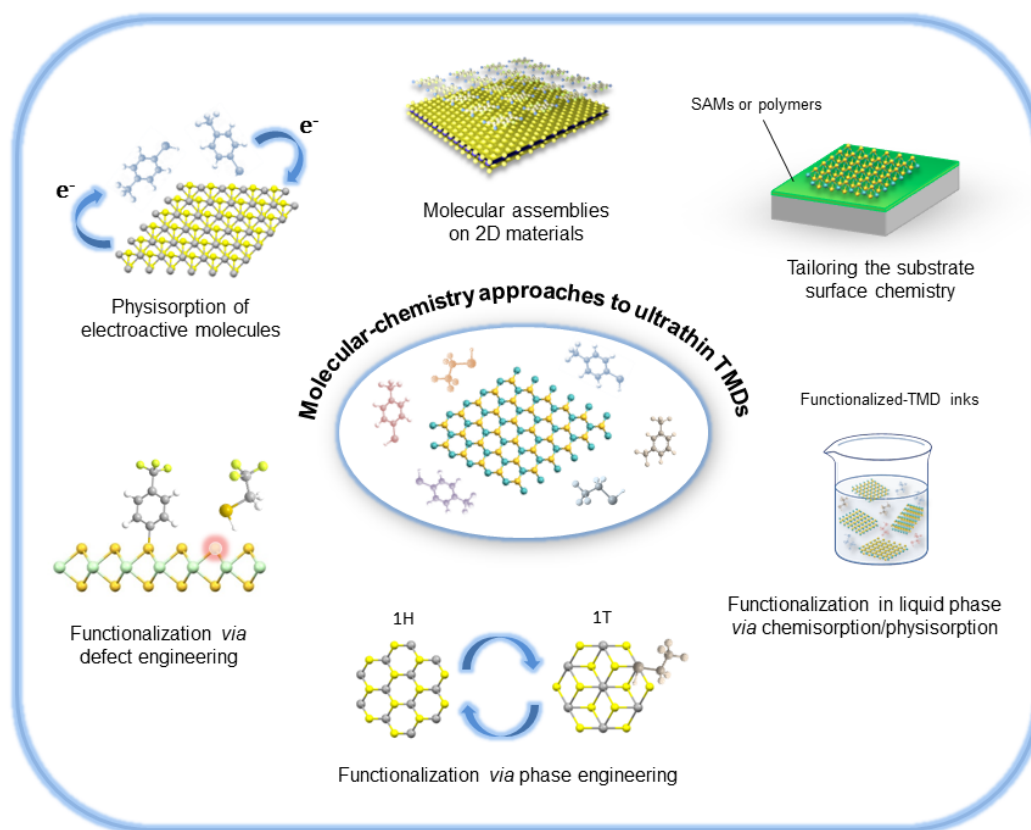


Fig. 1 Schematic representation of the different molecular chemistry approaches that have been investigated in the last years for tailoring the properties of ultrathin TMDs.

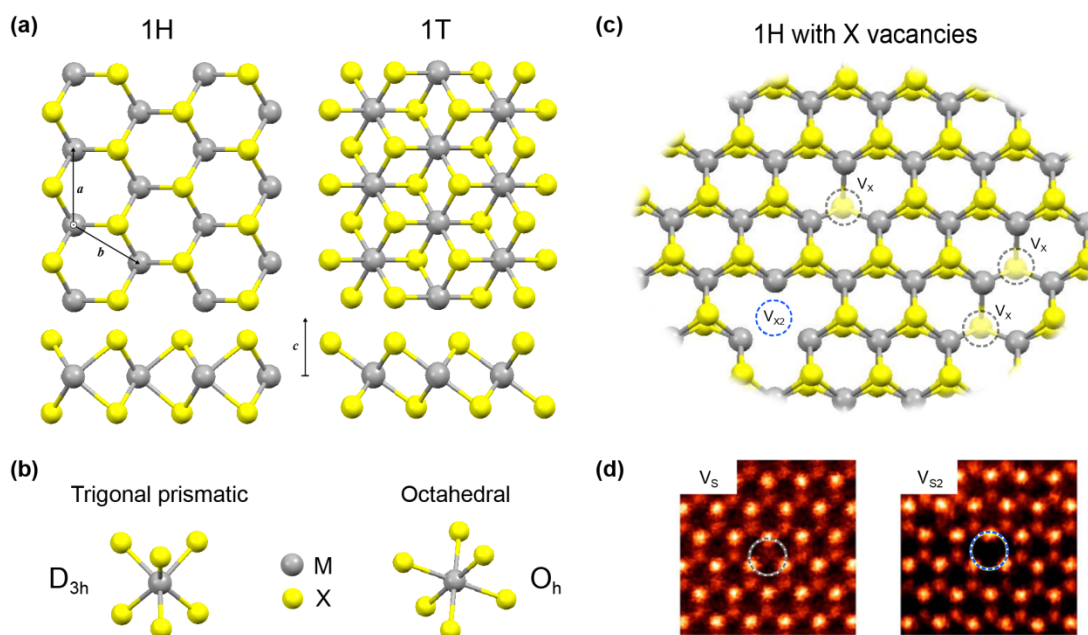


Fig. 2 Crystal structures and defects in monolayer TMDs. (a) Schematic illustration of the 1H (left) and 1T (right) polytypes, as seen along the c -axis (top) and a -axis (bottom) of the crystal. (b) Three-dimensional representation of the most common coordination geometries between M and X atoms. (c) Structure of single (V_X) and double (V_{X2}) chalcogen vacancies in 1H TMDs. (d) Atomic-resolution annular dark field (ADF) TEM images of single (left) and double (right) SVs present in monolayer MoS_2 sheets grown by CVD. (d) Adapted with permission from ref. 158. Copyright 2013 American Chemical Society.

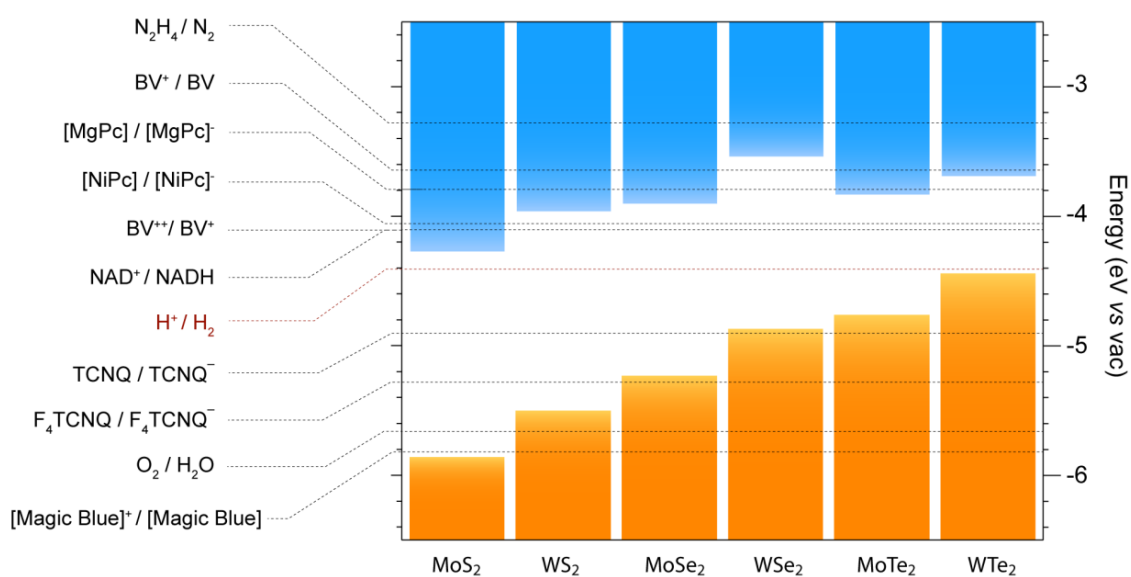


Fig. 3 Comparison between the electrochemical redox potentials of various molecular dopants and the band edges of group-6 TMDs. Approximate reduction potentials (eV vs vacuum) were derived from values reported in literature, namely hydrazine (N₂H₄),²¹⁴ benzyl viologen (BV),⁸⁵ magnesium phtalocyanine (MgPc),⁹⁹ nickel phtalocyanine (NiPc),⁹⁹ nicotinamide adenine dinucleotide (NADH),²⁰⁹ tetracyanoquinodimethane (TCNQ),²⁰⁹ tetrafluoro-7,7,8,8-tetracyanoquinodimethane (F₄-TCNQ),²⁰⁹ tris(4-bromophenyl)-ammoniumyl hexachloroantimonate (Magic Blue).²⁰¹ The CBM/VBM band edges (theoretical values) were taken from ref. 210.

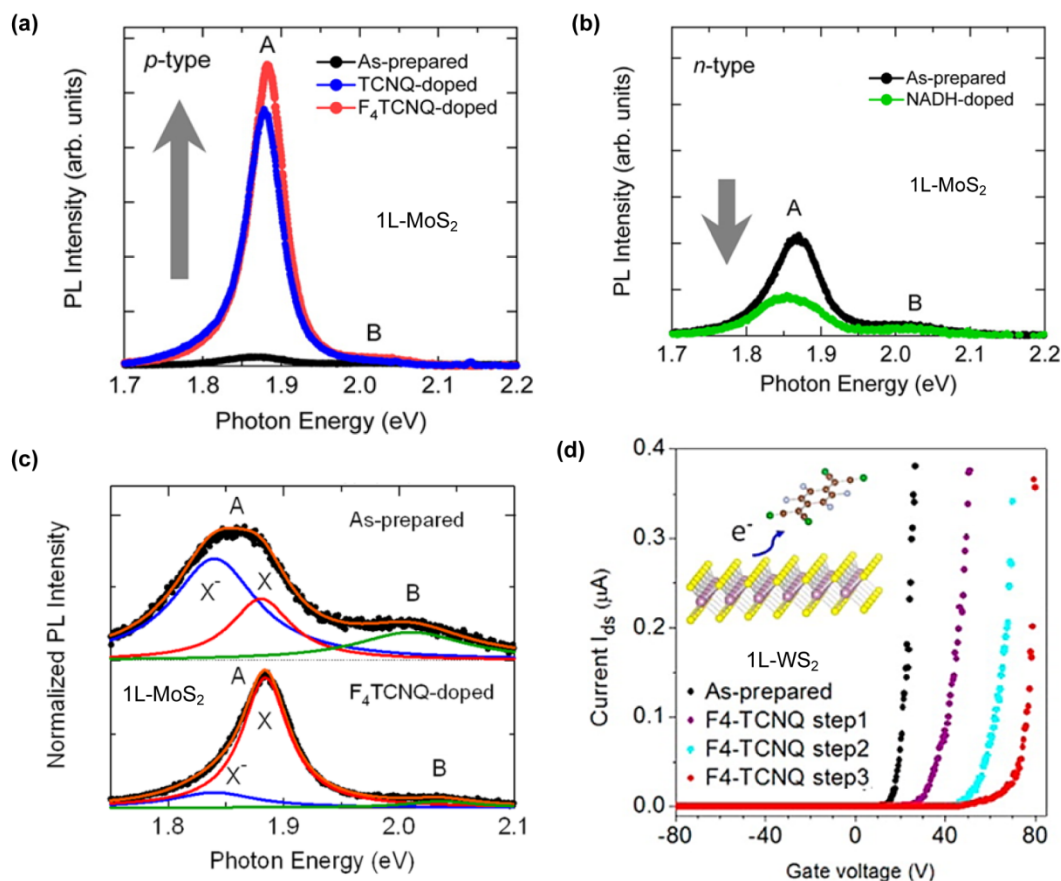


Fig. 4 Modulation of PL and electrical transport *via* molecular physisorption. (a) Effect of *p*-dopant TCNQ and F₄-TCNQ molecules, as well as (b) *n*-dopant NADH molecules on the PL spectra of monolayer (1L) MoS₂ sheets prepared by micromechanical cleavage. (c) Fitting of the PL spectra of as-prepared and F₄-TCNQ-doped 1L-MoS₂. The A peaks were fitted with trion (X⁻) and neutral exciton (X) contributions. (d) Transfer curves of a 1L-WSe₂ FET for different concentrations of F₄-TCNQ molecules. (a-c) Adapted with permission from ref. 209. Copyright 2013 American Chemical Society. (d) Adapted with permission from ref. 216. Copyright 2014 American Chemical Society.

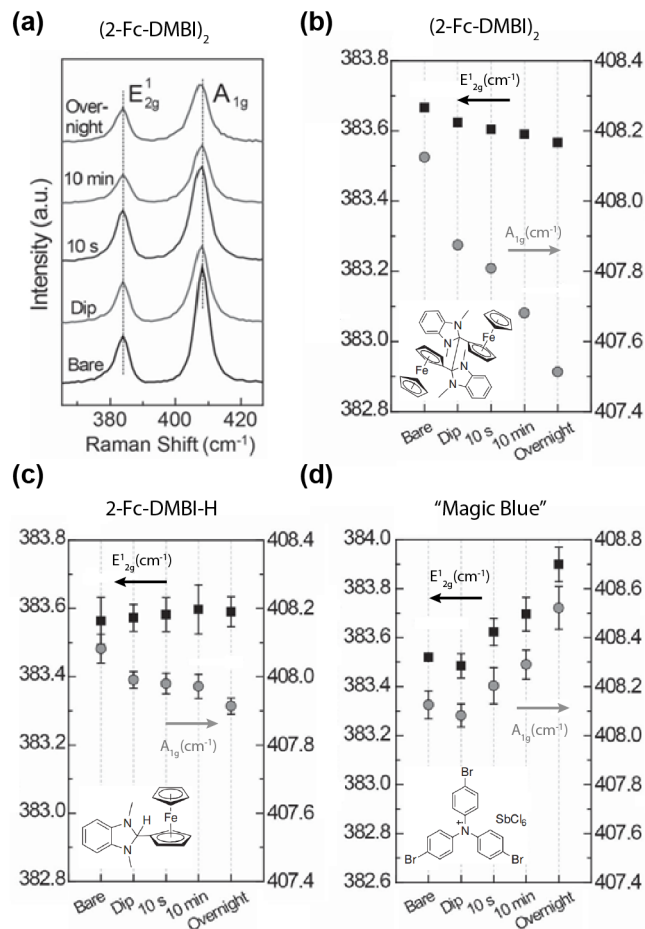


Fig. 5 Influence of physisorbed molecules on the Raman spectra of TMDs. (a) Raman spectra of few-layer MoS₂ sheets before and after different treatment with (2-Fc-DMBI)₂. (b-d) E_{2g}^1 (squares) and A_{1g} (circles) peak position shifts upon doping with (2-Fc-DMBI)₂, 2-Fc-DMBI-H and "Magic Blue", respectively. (a-d) Adapted with permission from ref. 87. Copyright 2015 Wiley-VCH.

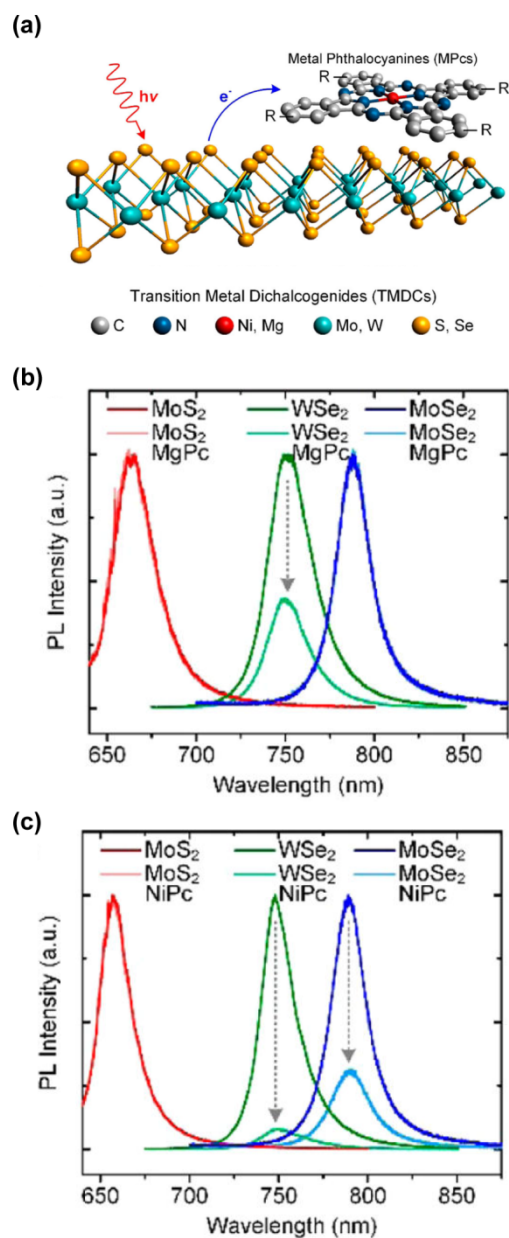


Fig. 6 Doping of TMDs by MPCs. (a) Schematic representation of a TMD sheet and a metallophthalocyanine molecule (MPC). (b, c) PL spectra of MoS₂, MoSe₂, and WSe₂ before and after physisorption of (b) NiPc and (c) MgPc. (a-d) Reprinted with permission from ref. 99. Copyright 2016 American Chemical Society.

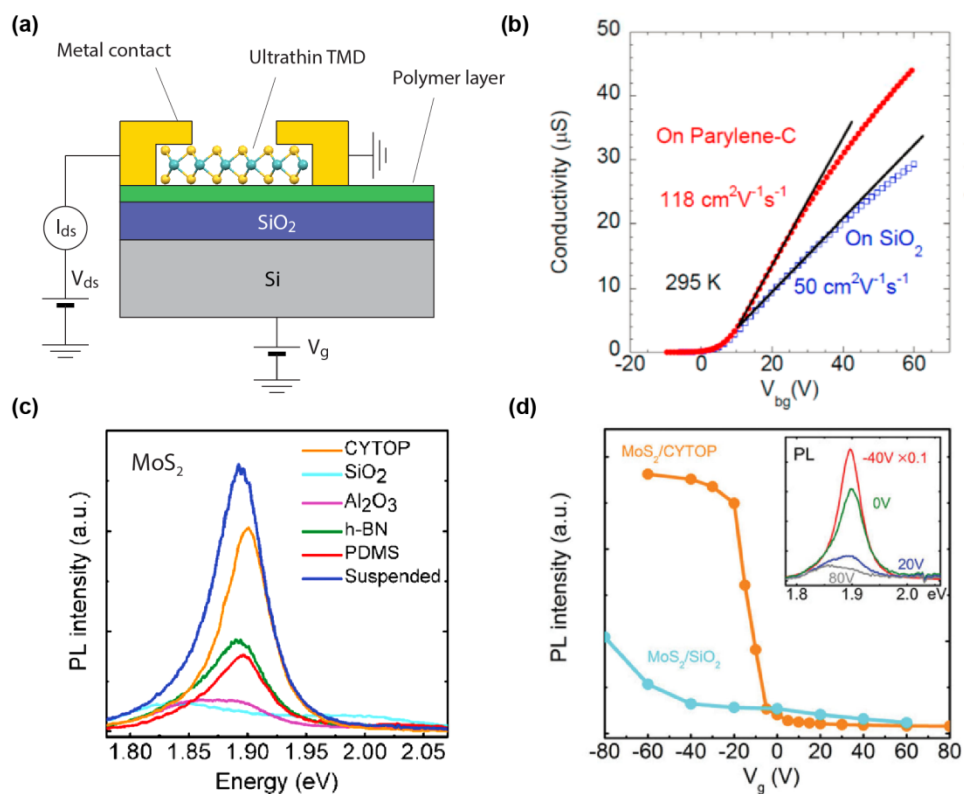


Fig. 7 Effects of polymer substrates on TMDs. (a) Structure of the FET device used to investigate the effects of polymer films on the charge-transport properties of ultrathin TMDs. (b) Transfer characteristics of few-layers MoSe₂ FETs built on parylene and SiO₂ substrates. (c) PL spectra of monolayer MoS₂ sheets deposited on different substrates. (d) Gate-voltage dependence of the PL intensity of monolayer MoS₂ on Cytop and SiO₂. Inset: PL spectra of monolayer MoS₂ on Cytop at various gate voltages. (b) Adapted with permission from ref. 205. Copyright 2014 American Chemical Society. (c, d) Adapted with permission from ref. 206. Copyright 2016 Wiley-VCH.

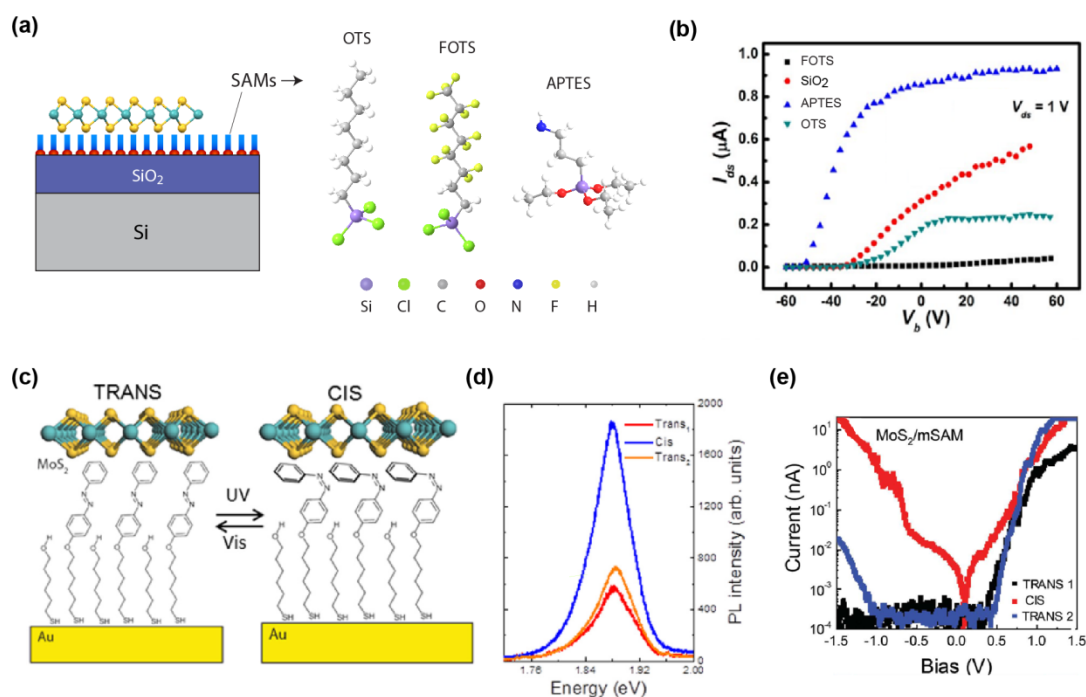


Fig. 8 The effect of SAM-modified substrates on TMDs. (a) Highly ordered molecules within the SAM are chemisorbed on the substrate surface and interact through weak van der Waals forces with TMD sheets deposited onto them. The chemical structure of the three silane coupling agents used in ref. 84 is also shown. (b) Transfer characteristics of few-layers MoS₂ onto the different SAMs. (c) Cartoon of photoswitchable AZO-SAM on gold substrates interacting with MoS₂. (d) Modification of the MoS₂ PL intensity accompanying the AZO-SAM switch. (e) Light-induced modulation of the electrical current flowing vertically across the SAM (from gold to MoS₂). (b) Adapted with permission from ref. 84. Copyright 2013 American Chemical Society. (c, d) Reprinted with permission from ref. 222. Copyright 2014 American Institute of Physics. (e) Adapted with permission from ref. 247. Copyright 2015 Wiley-VCH.

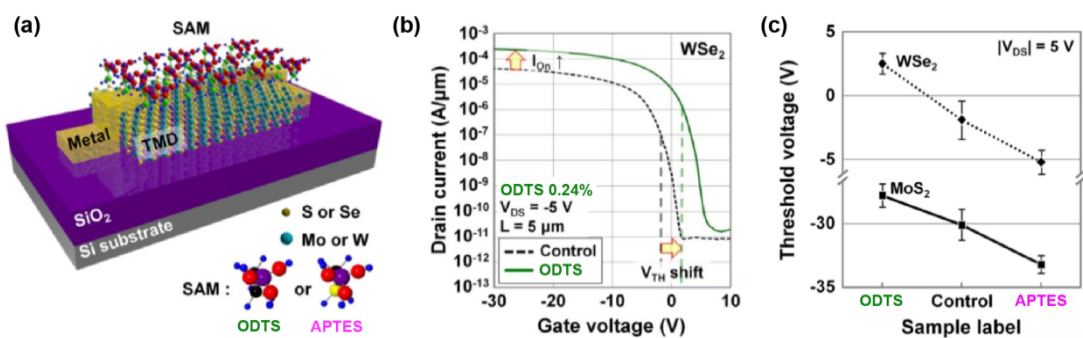


Fig. 9 Highly-ordered molecular layers on TMDs. (a) Schematic diagram of back-gated TMD transistors modified by ODTS or APTES treatments of the top surface. (b) Transfer characteristics of clean and ODTS-treated few-layer WSe₂ FETs built on SiO₂ substrates. (c) Threshold voltage shifts measured in few-layer TMD FETs treated with different molecules. Adapted with permission from ref. 39. Copyright 2015 Wiley-VCH.

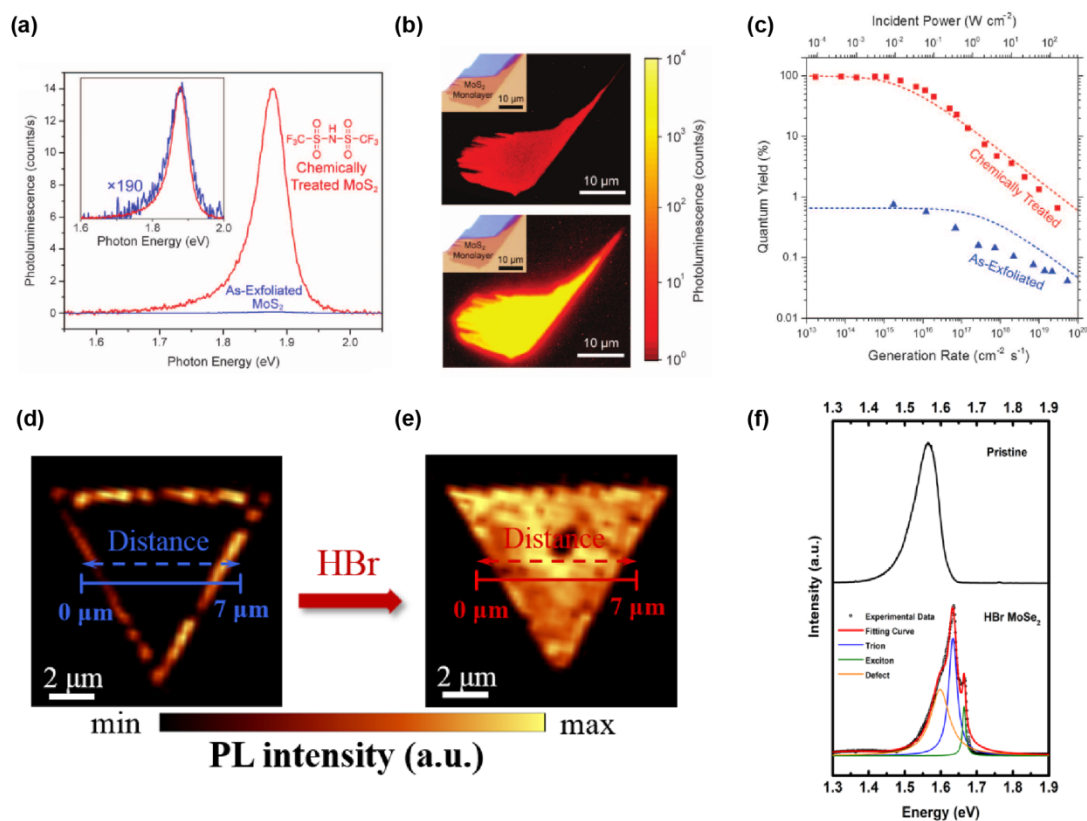


Fig. 10 Enhancement of the TMD PL by acid treatments. (a) PL spectrum for as-exfoliated and TFSI-treated MoS₂ monolayers. Inset: normalized spectra. The chemical structure of TFSI is also shown. (b) PL intensity maps of the same MoS₂ monolayer before and after the TFSI treatment. (c) Quantum yield dependence on the pump power, extracted from calibrated photoluminescence measured at different incident power. (d-e) PL intensity maps of an individual CVD-grown MoSe₂ monolayer before and after the HBr treatment. (f) PL spectra of pristine and HBr-treated MoSe₂ flake. (a-c) Reprinted with permission from ref. 97. Copyright 2015 AAAS. (d-f) Reprinted with permission from ref. 100. Copyright 2016 American Chemical Society.

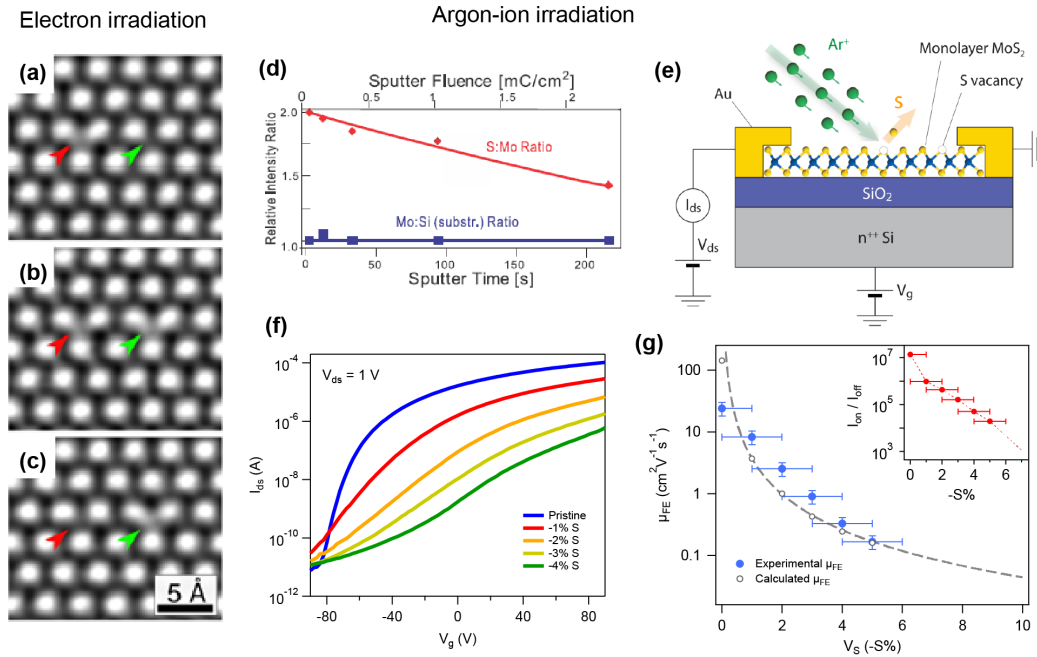


Fig. 11 Engineering chemically-active defects in ultrathin TMDs. (a-c) Aberration-corrected HR-TEM images demonstrating the generation of SVs *via* electron irradiation at 80 keV and the subsequent filling by impurity atoms. The red arrow in (a) indicates an initial SV that is filled by an impurity atom between (b) and (c), whereas the green arrow indicates a S atom that is ejected between (a) and (b) leaving a single vacancy. (d) Evolution of the stoichiometric ratio — as obtained from XPS measurements — of large-area CVD MoS₂ films exposed to an increasing dose of low-energy ($E \approx 500$ eV) argon ions. (e) Schematics of the ion-bombardment experiment performed on monolayer MoS₂ FETs. (f) Evolution of the transfer characteristics of the FET schematized in (e) with increasing density of SVs. (g) Experimental and theoretical evolution of the field-effect mobility μ_{FE} and I_{on}/I_{off} ratio (inset) with SV density. (a-c) Reprinted with permission from ref. 68. Copyright 2012 American Physical Society. (d) Reproduced with permission from ref. 274. Copyright 2013 IOP Science. (e-g) Reproduced with permission from ref. 109. Copyright 2017 Wiley-VCH.

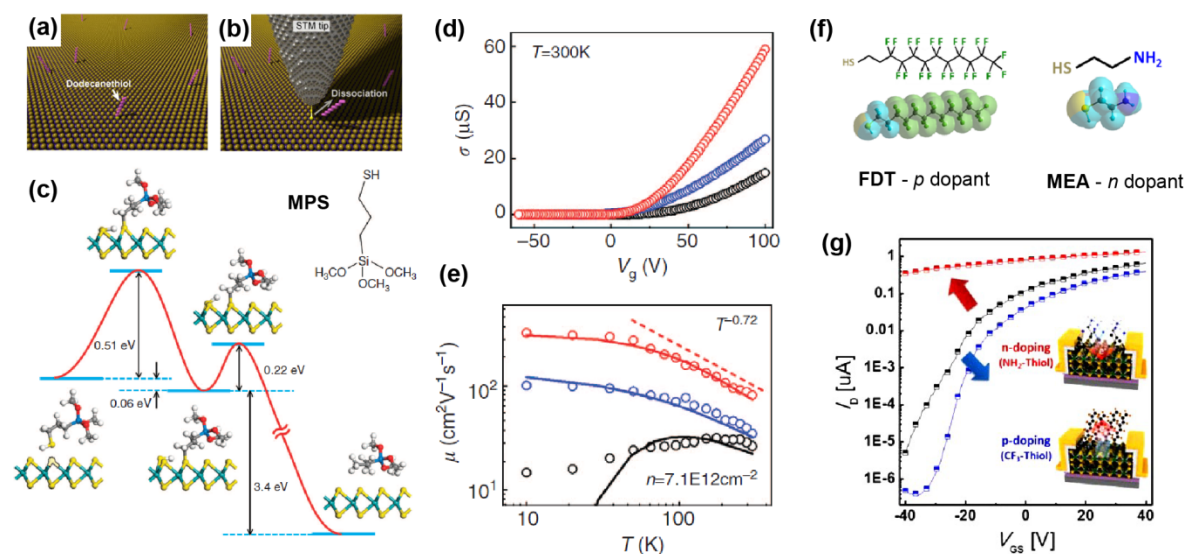


Fig. 12 Repair/functionalization of chemically-active defects in MoS₂. (a, b) Schematic representation of the STM experiments on the adsorption (a) and dissociation (b) of thiol molecules on the surface of a bulk 2H-MoS₂ crystal. (c) Kinetics and transient states of the reaction between a single SV and MPS. (d, e) Effect of the MPS treatment on the transfer characteristics (d) and field-effect mobility (e) of monolayer MoS₂ FETs. Black: no treatment. Blue: top surface treatment. Red: bottom and top surface treatment. (f) Molecular dopants with thiol anchoring groups. The molecules have same spacer group (two carbon atoms) between the doping and anchoring units. (g) Transfer characteristics of untreated (black), FDT-treated (blue) and MEA-treated (red) few-layer MoS₂ FETs. (a, b) Adapted with permission from ref. 181. Copyright 2012 American Chemical Society. (c-e) Adapted with permission from ref. 182. Copyright 2014 Nature Publishing Group. (f, g) Adapted with permission from ref. 88. Copyright 2015 American Chemical Society

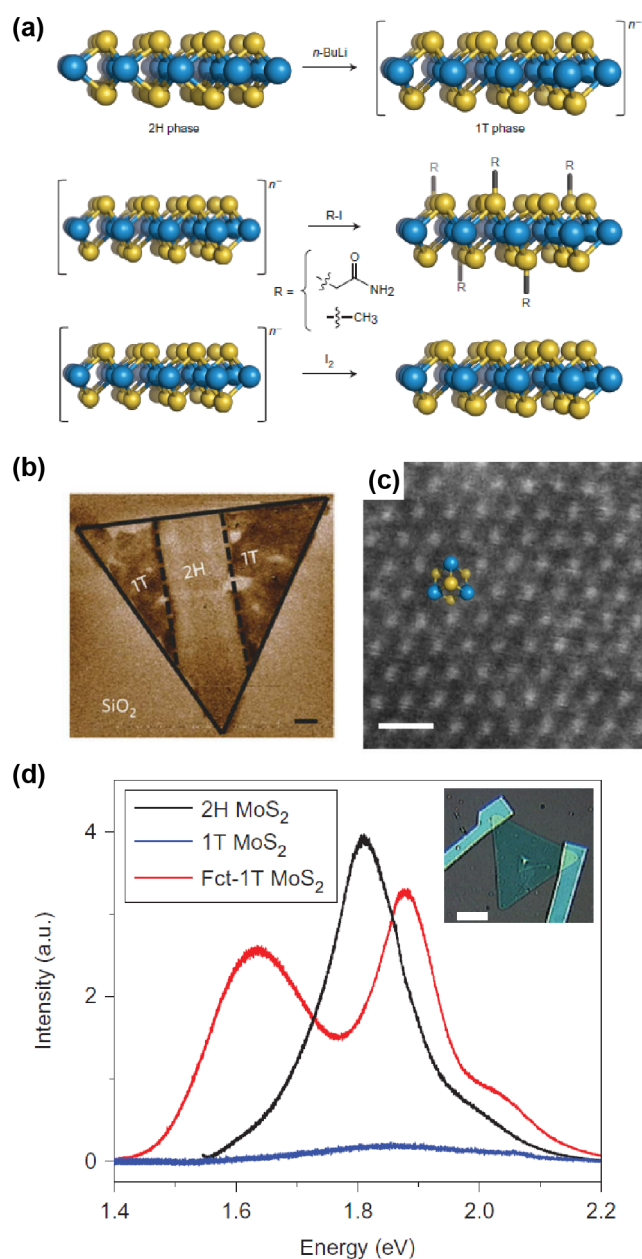


Fig. 13 Covalent functionalization of MoS₂ *via* phase engineering. (a) Schematics of the functionalization approach based on the reaction of 1T-MoS₂ nanosheets with organohalides. (b) Electrostatic force microscopy phase image of a CVD-grown MoS₂ sheet with locally patterned metallic and semiconducting regions. Scale bar: 1 μ m. (c) High annular angle dark field scanning TEM images of functionalized monolayer MoS₂ sheets with octahedral coordination. Scale bar: 0.5 nm. (d) PL spectra of a CVD-grown MoS₂ sheet at different stages of the functionalization process: pristine (black), after exposure to *n*-butyllithium (blue) and after functionalization (red). (a, c, d) Adapted with permission from ref. 80. Copyright 2015 Nature Publishing Group. (b) Reproduced with permission from ref. 308. Copyright 2014 Nature Publishing Group.

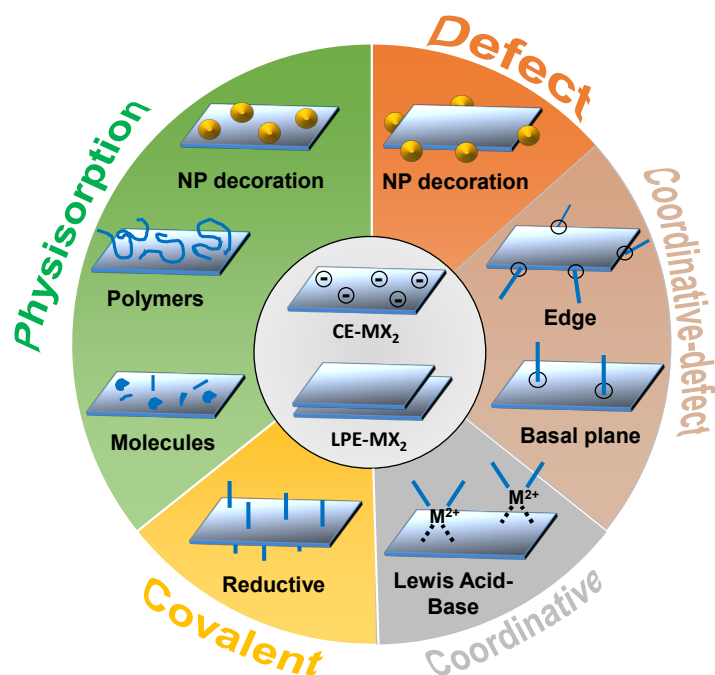


Fig. 14 Overview of functionalization strategies for TMDs in the liquid phase based on chemically exfoliated (CE-MX₂) and liquid phase exfoliated (LPE-MX₂) nanosheets. In addition to physisorption, different approaches for chemisorption exist. These can be classified as covalent (involving X-C bonds), coordinative (involving chalcogens as ligands) and defect functionalization. Defects such as chalcogen vacancies can also be used for coordination chemistry involving dative bonds with nucleophiles.

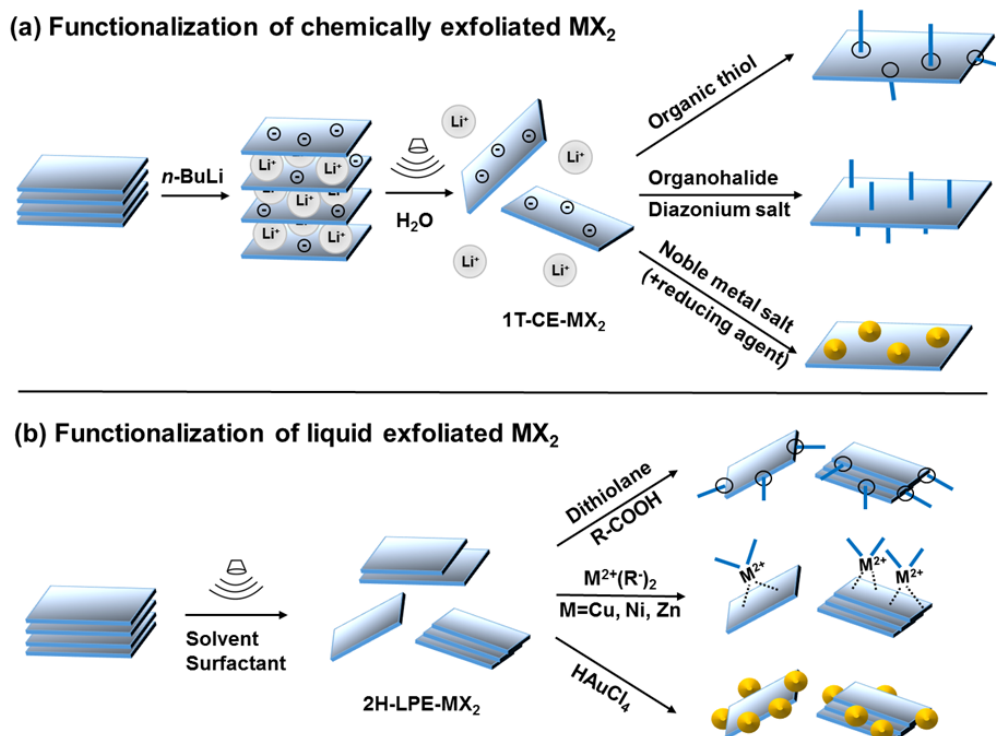


Fig. 15 Schematic of reaction pathways to achieve functionalization *via* chemisorption. (a) Pathways building on chemical exfoliation *via* intercalation with n-butyllithium. This process yields negatively charged MX₂ nanosheets in the 1T/1T' polytype which can be further derivatized *via* i) coordination of thiols to chalcogen vacancy sites (defect functionalization), ii) reductive covalent functionalization with electrophiles such as organohalides or diazonium salts, or iii) physisorption of metal nanoparticles. (b) Pathways building on liquid phase exfoliation in appropriate solvents or aqueous surfactants. This strategy yields few-layered nanosheets of the semiconducting 2H-polytype. These can be functionalized by i) coordination of electron donors (dithiolanes or carboxylic acids) to sulfur deficient edges, ii) coordination to metal complexes using the chalcogen as ligand, or iii) nanoparticles covalently bound to nanosheet edges.

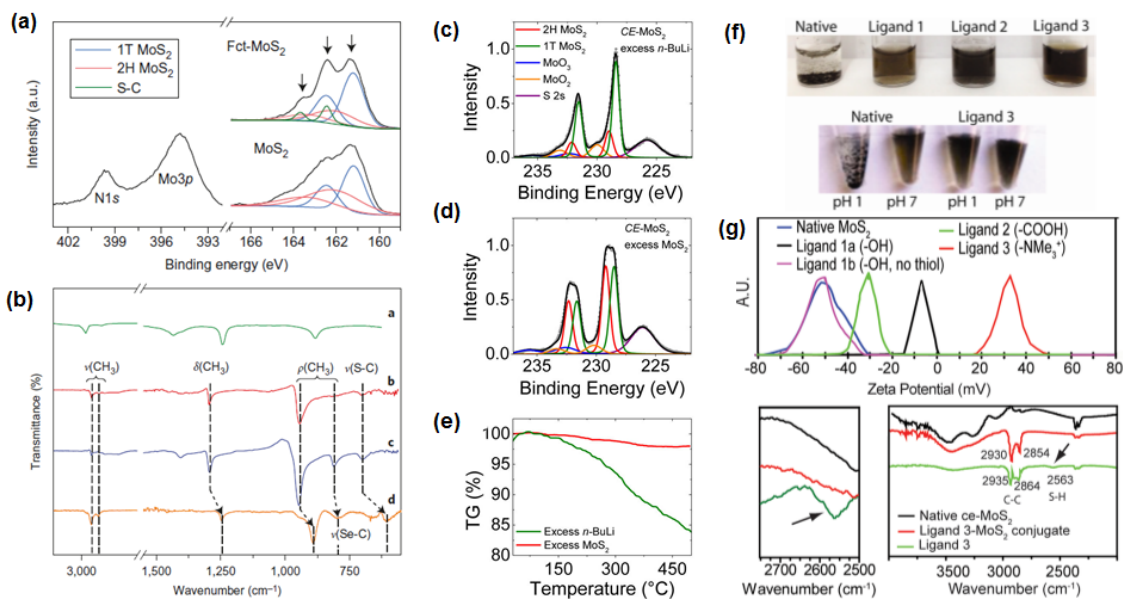


Fig. 16 Covalent reductive and coordinative functionalization of MX_2 in liquids. (a, b) Reductive covalent functionalization according to ref. 80. (a) Sulfur XPS core level spectra showing evidence for an additional sulfur species due to the formation of a covalent S-C bond. (b) IR spectra 1T-MoWSe₂ reductively functionalized with iodomethane. From top to bottom: iodomethane (green), functionalized 1T-MoS₂ (red), 1T-WSe₂ (blue) and 1T-MoSe₂ (orange). (c-e) Tuning of 2H/1T content in MoS₂ via intercalation conditions. (c, d) Mo core level spectra after n-BuLi intercalation using (c) excess n-BuLi over MoS₂ and (d) excess MoS₂ over n-BuLi. (e) Thermogravimetric weight loss of the samples in (c, d) showing negligible weight loss in the case of the intercalation with excess MoS₂ suggesting lower defect contents. (f, g) Coordination of thiols to vacancy sites from ref. 259. (f) Top: photographs of 1T-MoS₂ dispersions after reaction with various ligands, bottom: corresponding zeta potential changes from negative to positive potentials depending on the ligand. (g) IR spectra of the samples showing the disappearance of the S-H vibration (left), but the presence of the rest of the ligand (right). (a,b) Reproduced with permission from ref. 80. Copyright 2015 Nature Publishing Group. (c-e) Reproduced with permission from ref. 260. Copyright 2015 American Chemical Society. (f, g) Reproduced with permission from ref. 259. Copyright 2013 American Chemical Society.

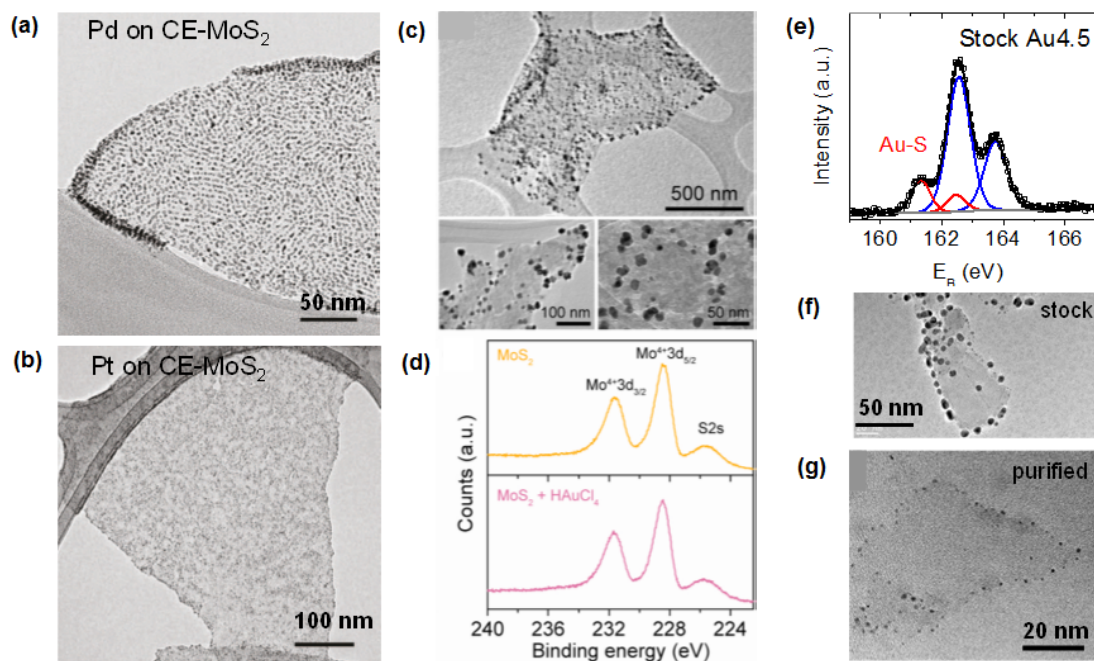


Fig. 17 MX₂ nanoparticle decoration. (a-d) Nanoparticles epitaxially grown on 1T-MoS₂. (a-c) TEM images of (a) Pd on 1T-MoS₂, (b) Pt on 1T-MoS₂, (c) Au on 1T-MoS₂. (d) XPS Mo core level spectra showing no changes to the MoS₂ on reaction with the metal precursor. (e-g) Au nanoparticles grown on LPE-2H-WS₂ from ref. 404. (e) XPS sulfur core level spectra showing evidence for covalent binding of the nanoparticles to the WS₂. (f, g) TEM images of Au-decorated LPE-2H-WS₂ before (f) and after (g) purification. (a, b) Reproduced with permission from ref. 394. Copyright 2013 Nature Publishing Group. (c, d) Reproduced with permission from ref. 395. Copyright 2013 American Chemical Society. (e-g) Reproduced with permission from ref. 404. Copyright 2018 Nature Publishing Group.

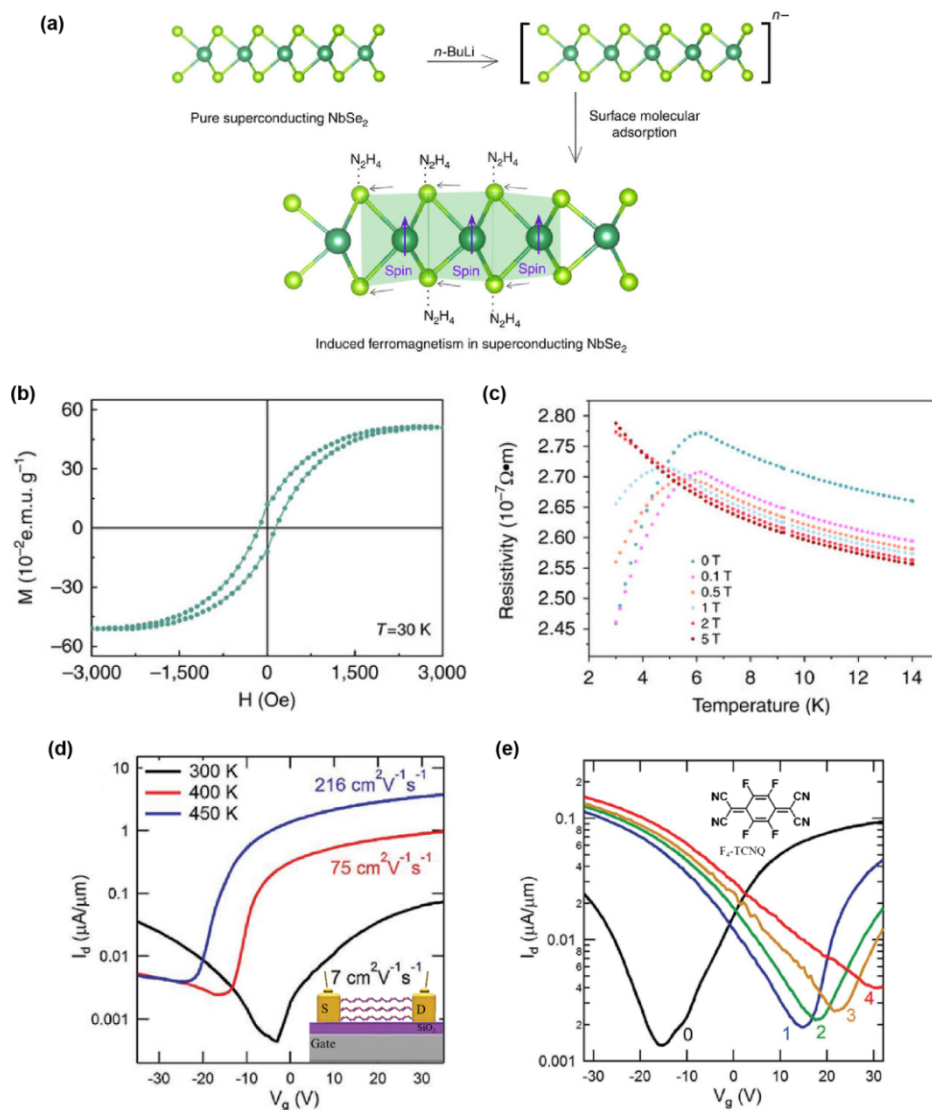


Fig. 18 Tailoring TMDs “beyond MoWSeS” *via* molecular physisorption. (a) 2H NbSe₂ nanosheets are exfoliated *via* lithium-ion intercalation. Physisorbed hydrazine molecules trigger a structural distortion of the crystal together with novel ferromagnetic properties in superconducting NbSe₂. (b) Magnetization *vs* magnetic field (*M–H*) curves of hydrazine-treated NbSe₂ at 30 K. (c) Temperature-dependent electrical resistivity (*R–T* curves) of hydrazine-treated NbSe₂ under different magnetic fields. (d) Transfer curves of a PdSe₂ FET showing a progressive conversion from ambipolar to unipolar *n*-type transport upon thermal annealing. (e) Transfer curves of a PdSe₂ FET showing a continuous change from ambipolar to unipolar *p*-type transport *via* F₄-TCNQ physisorption doping. (a–c) Reprinted with permission from ref. 114. Copyright 2016 Nature Publishing Group. (d–e) Reprinted with permission from ref. 113. Copyright 2017 Wiley-VCH.

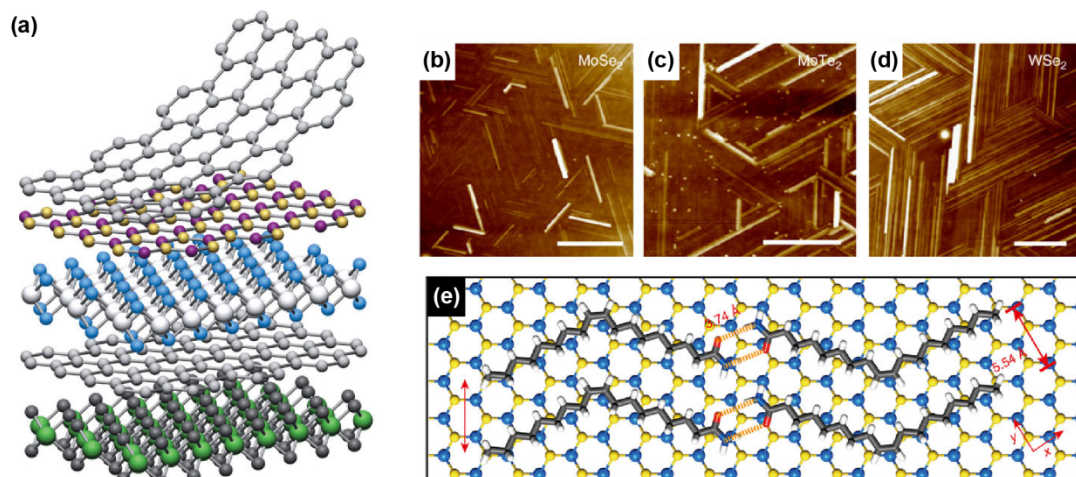


Fig. 19 Hybrid van der Waals heterostructures. (a) TMDs and other 2D Materials can be superimposed to construct a variety of layered structures with opto electronic properties fundamentally different from those of the isolated sheets. (b-d) AFM images of a highly-ordered molecular monolayers on the surface of MoSe₂ (b), MoTe₂ (c), WSe₂ (d). (e) Schematics of the nanoscale molecular arrangement giving rise to the lamellar assembly observed in panels (b-d). Analogous molecular monolayers could be integrated within inorganic van der Waals heterostructures (a) to obtain hybrid organic/inorganic materials with unique properties. (a) Reprinted with permission from ref. 419. Copyright 2013 Nature Publishing Group. (b-e) Reprinted with permission from ref. 252. Copyright 2016 American Institute of Physics.